



Ultrashort Pulse (USP) Laser – Matter Interactions

5 MAR 2013

Dr. Riq Parra
Program Officer
AFOSR/RTB

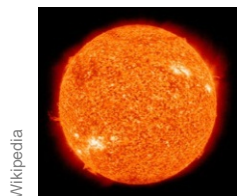
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Modelocked femtosecond lasers



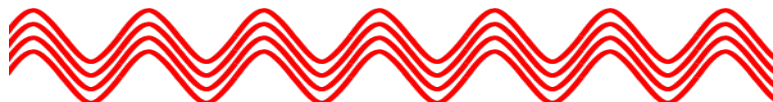
Sunlight



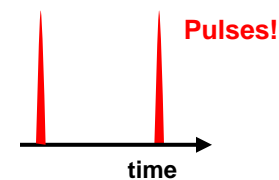
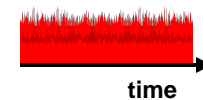
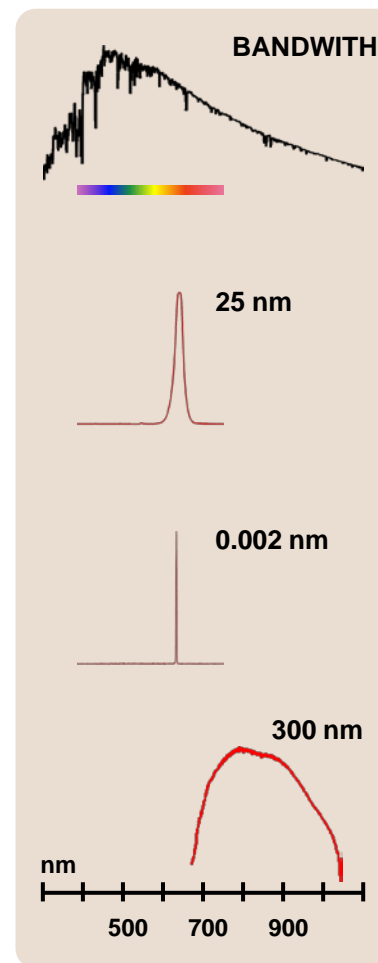
Light Emitting Diode



He-Ne cw laser

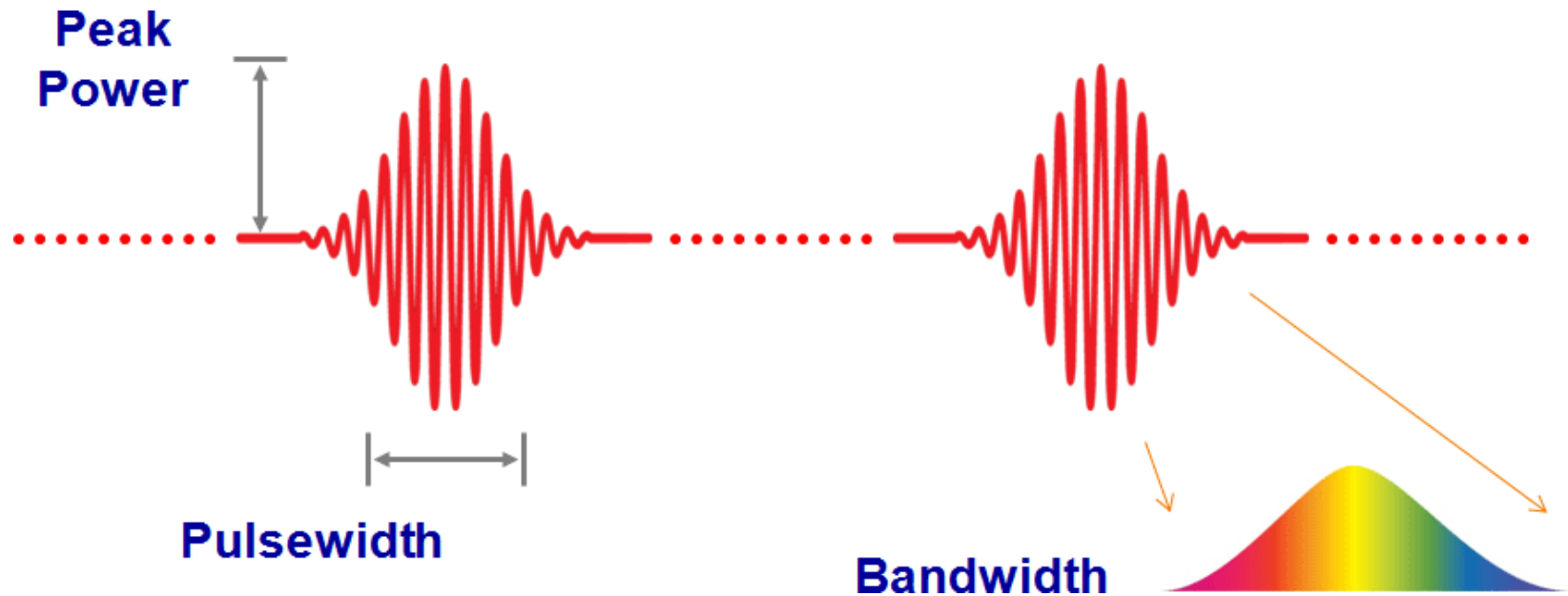


Ti:Sapphire modelocked fs laser





2013 AFOSR SPRING REVIEW 3001O PORTFOLIO OVERVIEW



- The program aims to understand and control light sources exhibiting extreme bandwidth, peak power and temporal characteristics.
- Portfolio sub-areas: optical frequency combs, high-field science, attosecond physics.



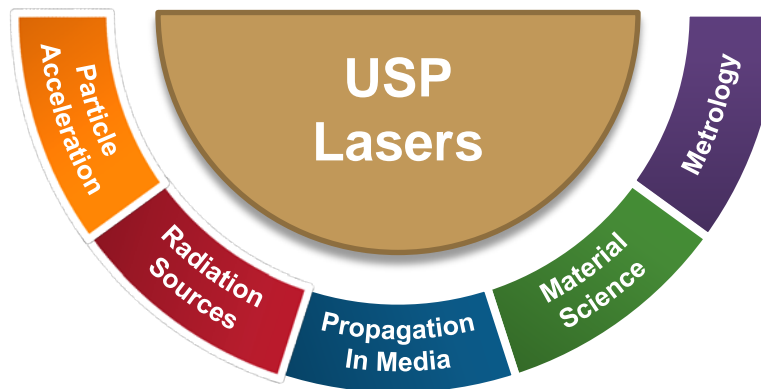
Applications of USP Lasers



Particle Acceleration

ultrahigh electric field gradients

- Table-top GeV electron accelerators
- MeV ion sources for imaging
- Isotope production
- Hadron tumor therapy
- Proton-based fast ignition



Metrology

stabilized, ultra-wide bandwidth

- Ultra-stable freq sources
- Optical waveform synthesis
- High precision spectroscopy
- Frequency/time transfer
- High-capacity comms
- Coherent LIDAR
- Optical clocks
- Calibration

Secondary Radiation Sources

generation of particle & photons

- High power THz generation
- Extreme ultraviolet lithography
- Biological soft x-ray microscopy
- Non-destructive evaluation
- Medical imaging/therapy

Propagation in media

self-channeling

- Remote sensing
- Remote tagging
- Directed energy
- Electronic warfare
- Countermeasures
- Advanced sonar

Material Science

ultrashort, high peak power

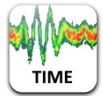
- Surgery
- Chemical analysis (LIBS)
- Surface property modification
- Non-equilibrium ablation
- Micromachining
- Ultrafast photochemistry
- Attochemistry



Outline



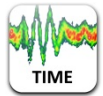
— Microresonator-based optical frequency combs



— High peak power, ultrashort pulse laser processing of materials



— Extreme ultraviolet (EUV) comb spectroscopy



— High harmonic interferometry



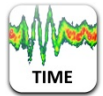
— Relativistic optics



Outline



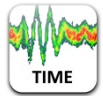
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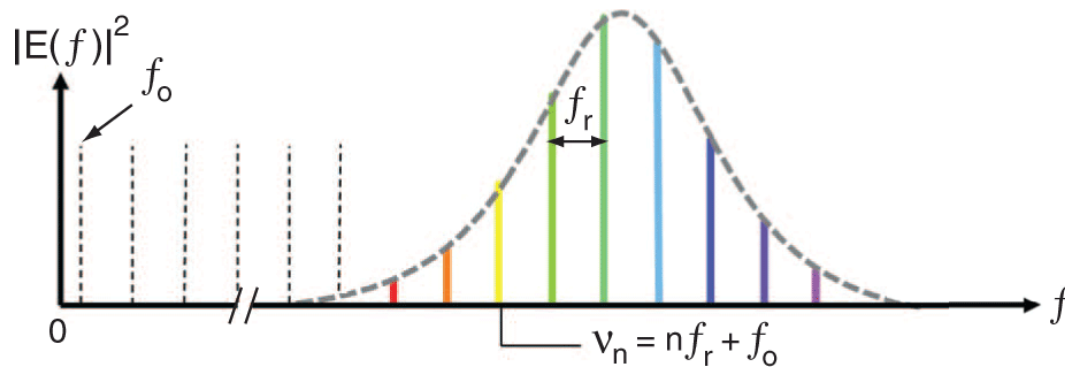
— Relativistic optics



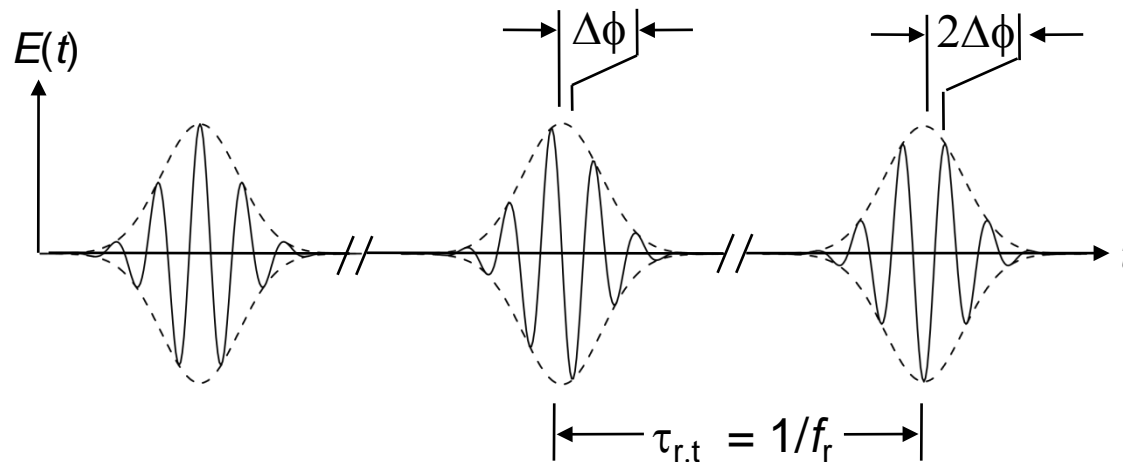
Optical frequency combs: Frequency & time domains



**Frequency
domain**

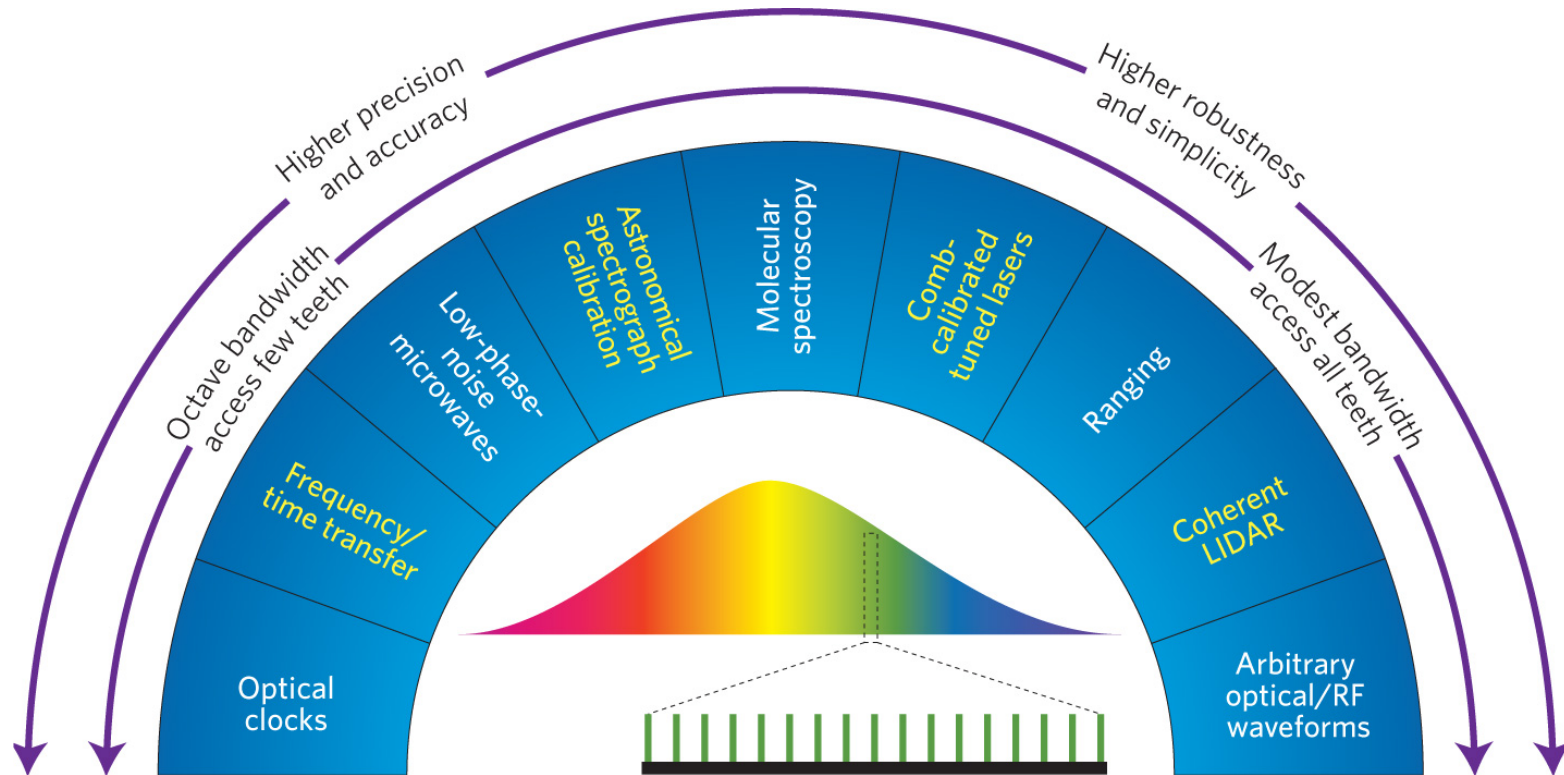


**Time
domain**





Metrological applications of optical frequency combs



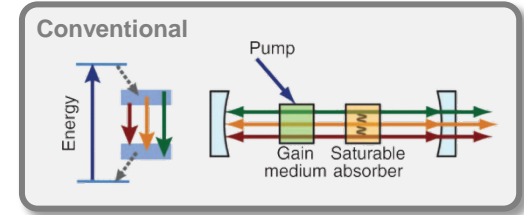
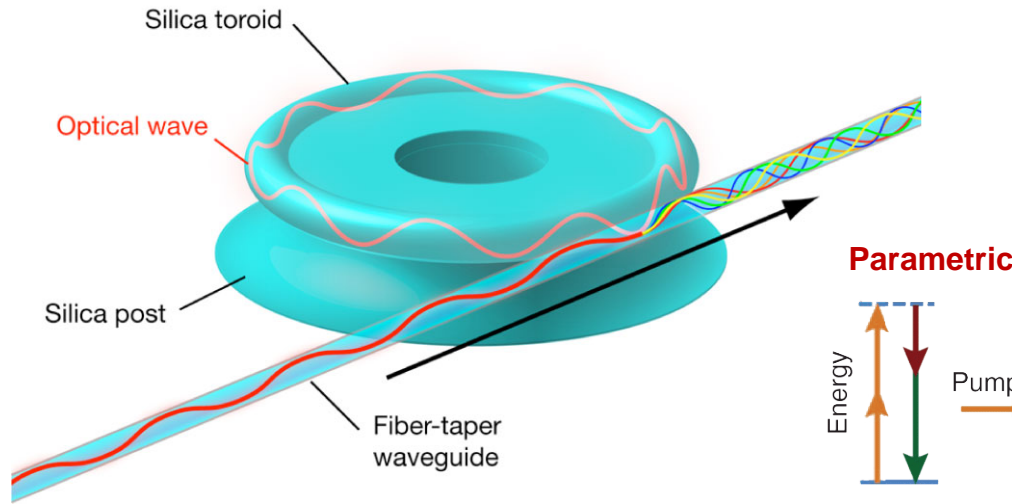


Combs in monolithic microresonators

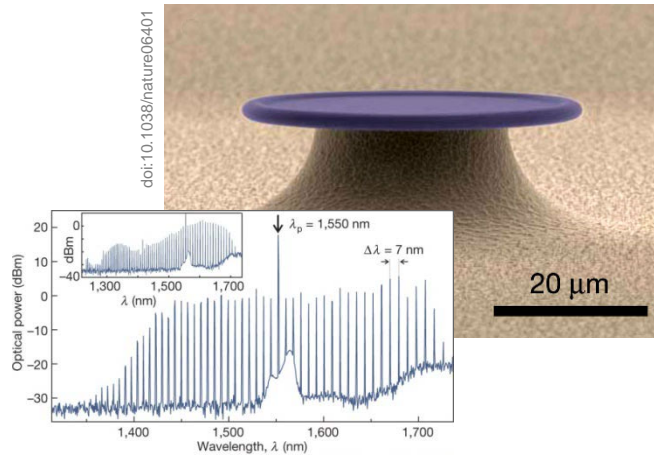


Source: Kippenberg et al., Science (2011)

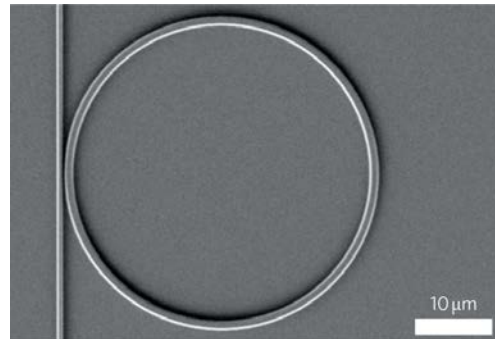
Source: Braje, Physics 3, 75 (2010)



Silica toroids

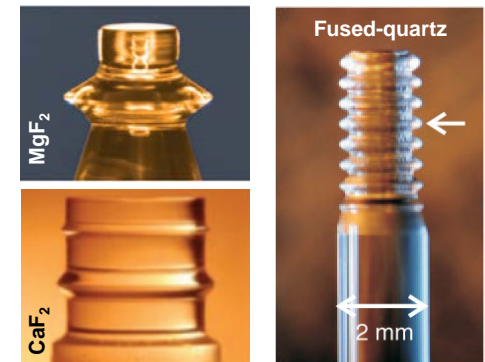


Silicon nitride microrings



doi: 10.1038/nphoton.2009.259

High-Q mm crystalline resonators



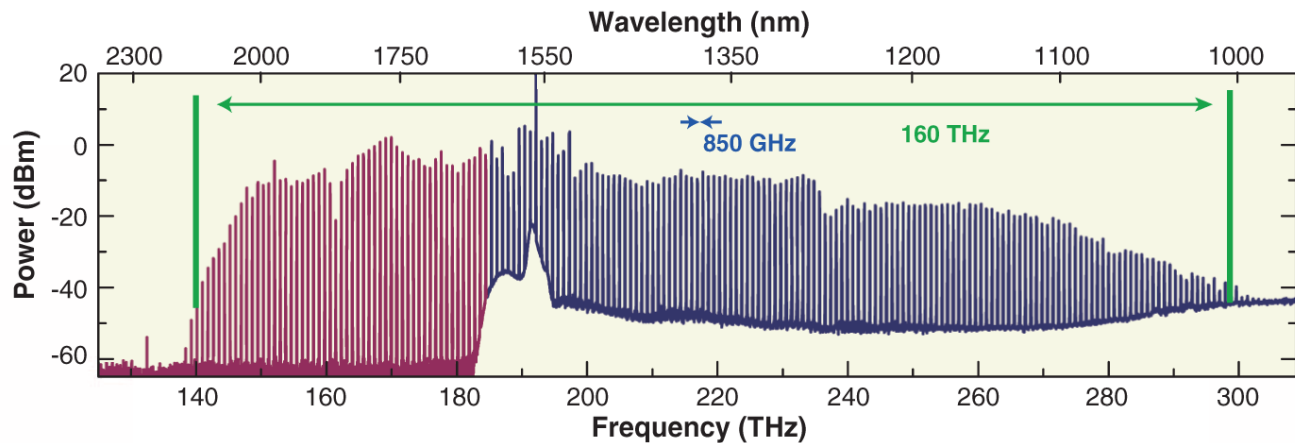
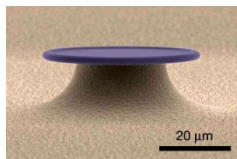
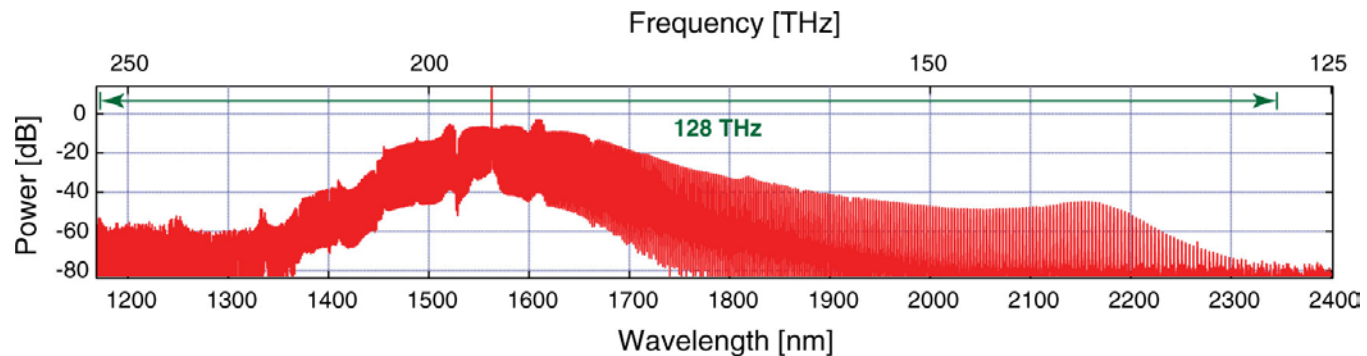
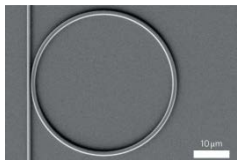
top left doi: 10.1038/nphoton.2012.127

right doi: 10.1103/physrev.84.053833

bottom left doi: 10.1103/physrevlett.101.093902

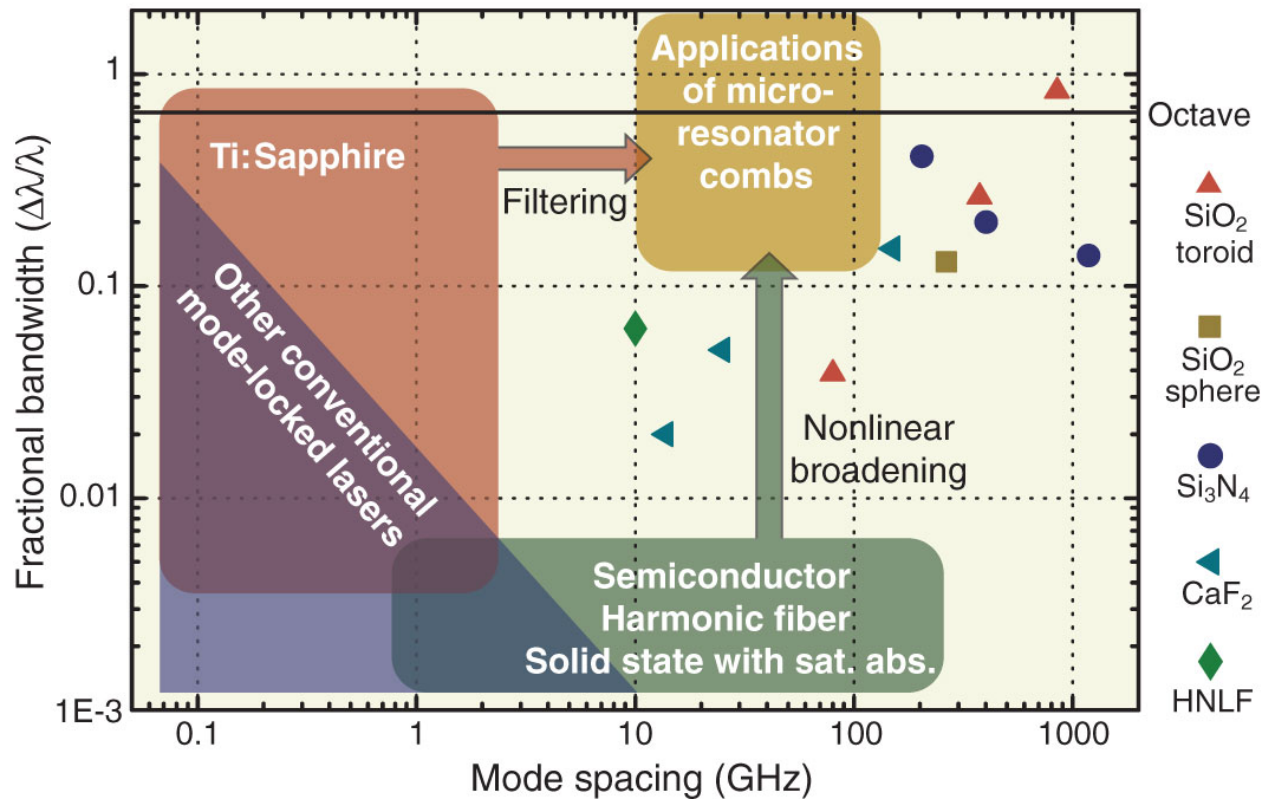
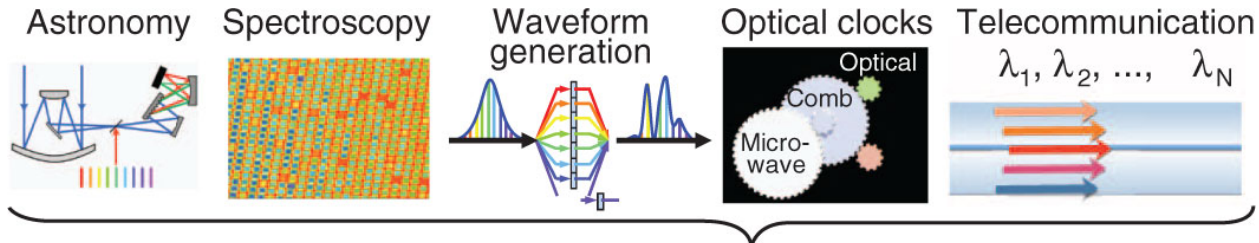


Octave spanning bandwidths



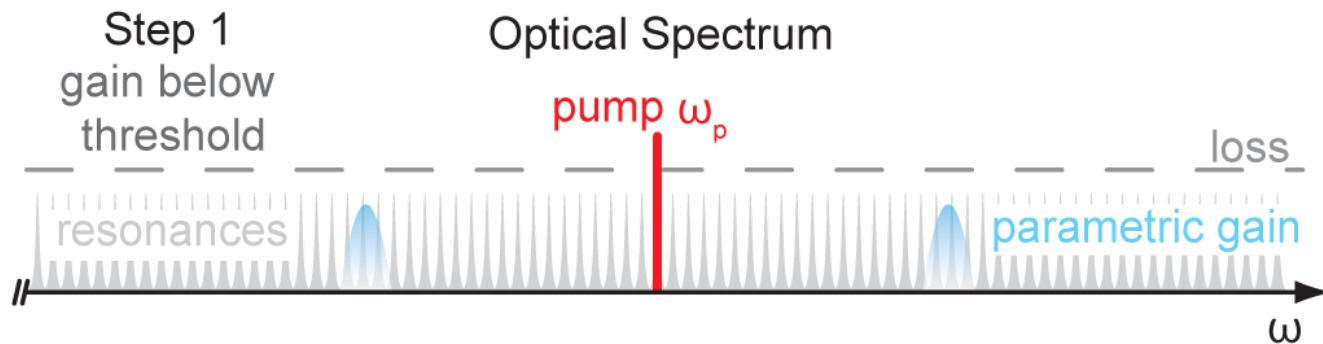


Why microresonators?



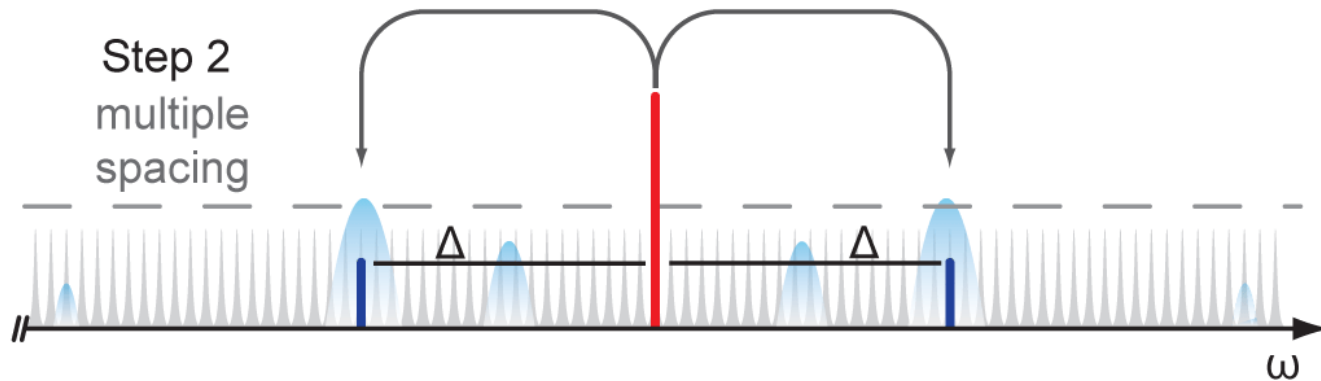


Comb generation dynamics



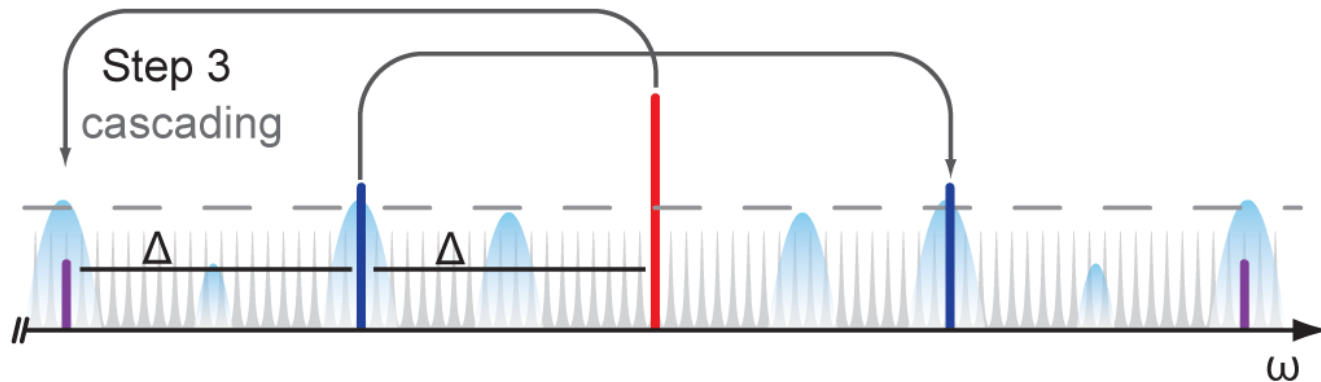


Comb generation dynamics



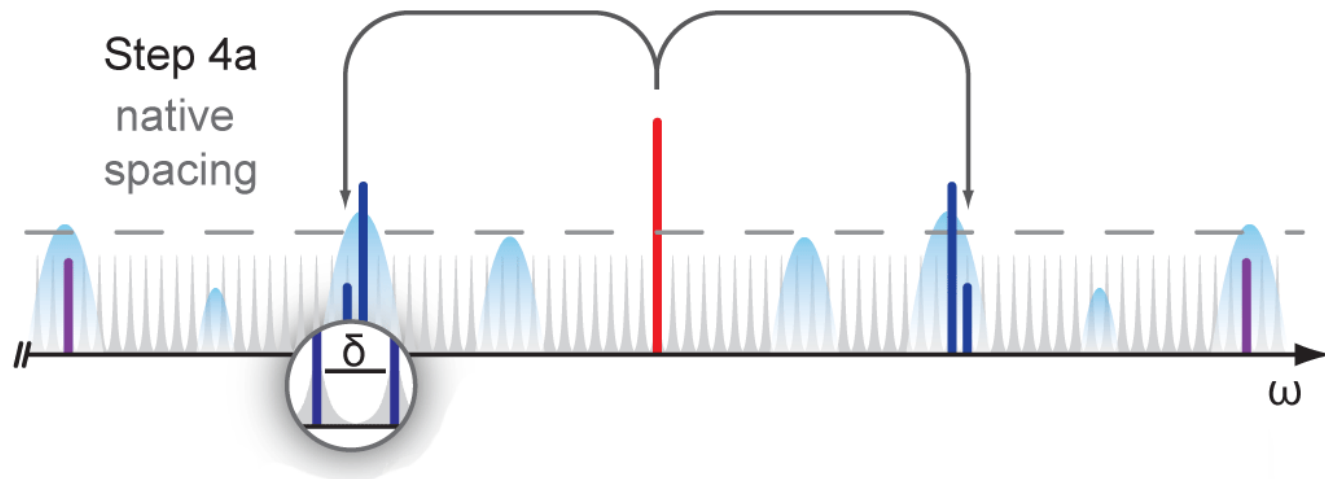


Comb generation dynamics



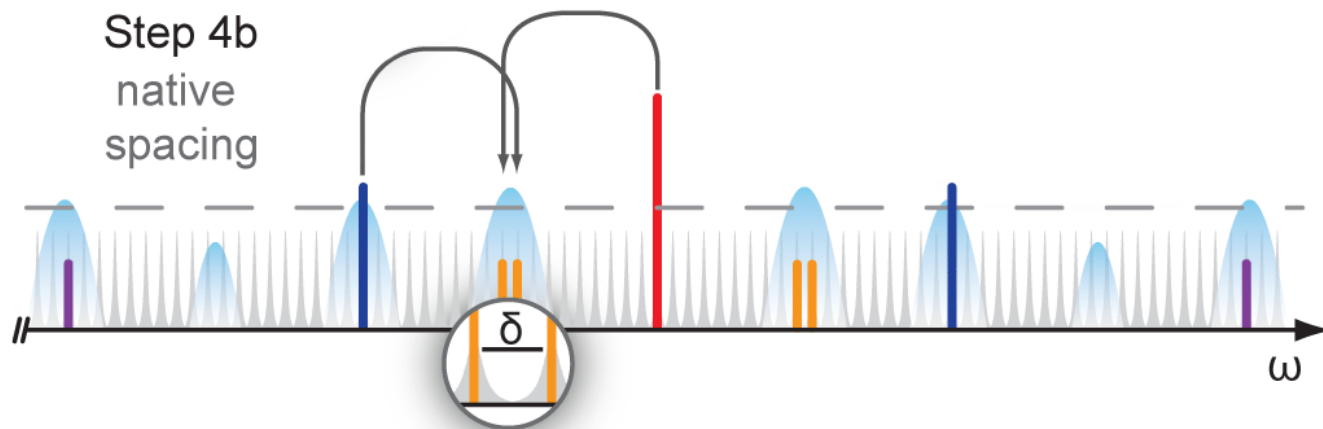


Comb generation dynamics



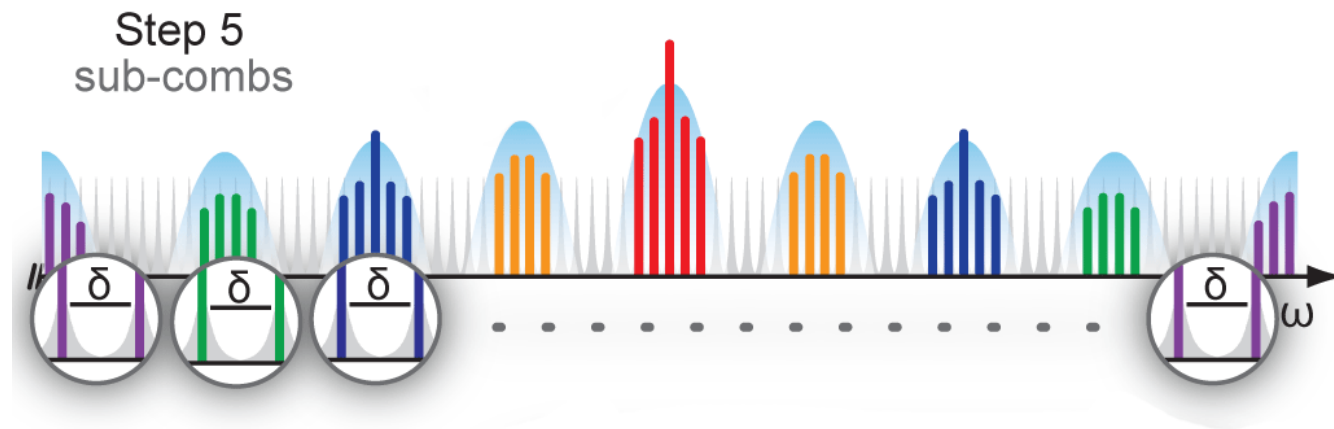


Comb generation dynamics



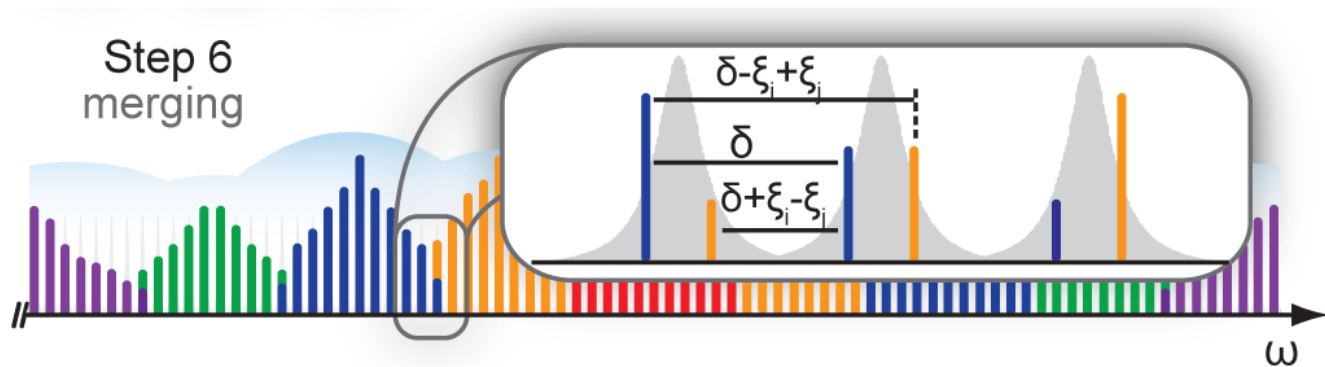


Comb generation dynamics





Comb generation dynamics





(FY12 BRI) Microresonator-based optical frequency combs



S. Diddams
NIST



Q. Lin
UNIVERSITY of ROCHESTER



A. Gaeta
Cornell



A. Matsko
OEwaves

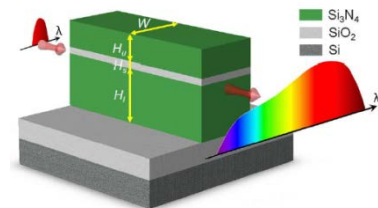
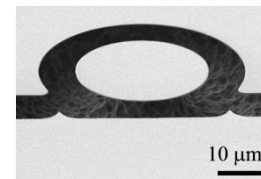


A. Weiner
PURDUE UNIVERSITY



A. Willner
USC Optical Communications Laboratory

- Initiative aimed at exploring the fundamental physics of microresonator comb generation.
- Six efforts exploring:
 - Spatio-temporal field mapping and control
 - Silicon-carbide microdisks
 - Silicon nitride resonators
 - Mid-IR microresonators
 - Time domain characterization
 - Dispersion tailoring via slotted waveguides



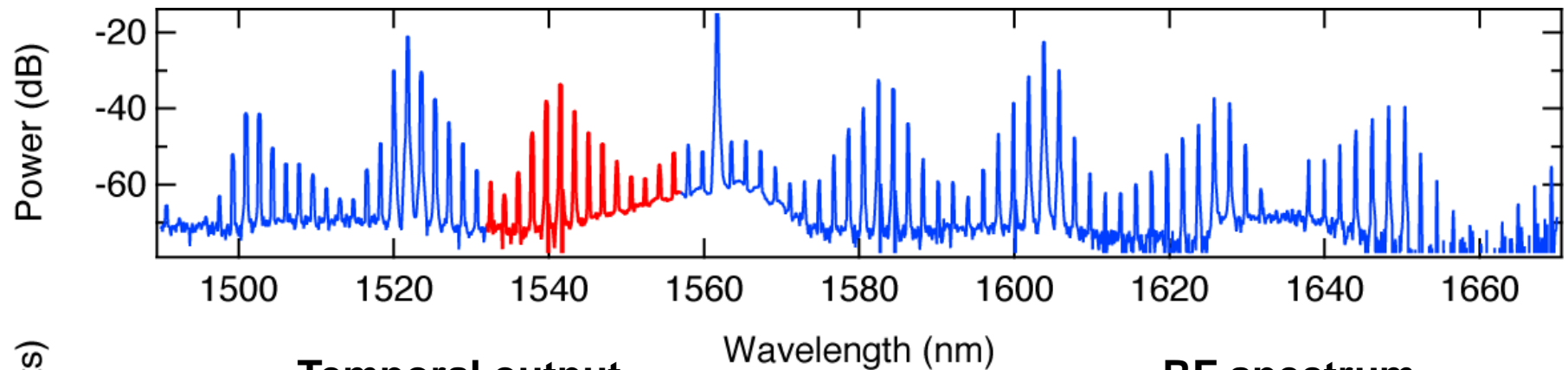


Temporal and Spectral Comb Generation Dynamics

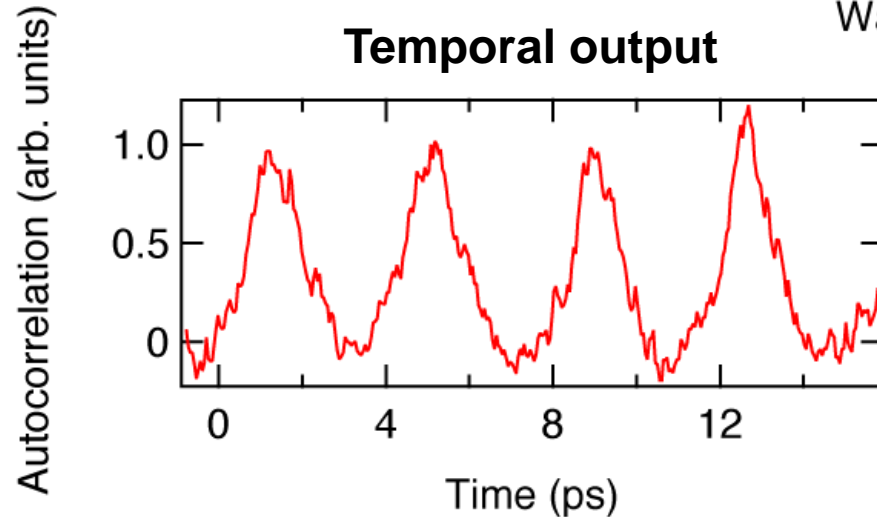


PI: Alex Gaeta, Cornell

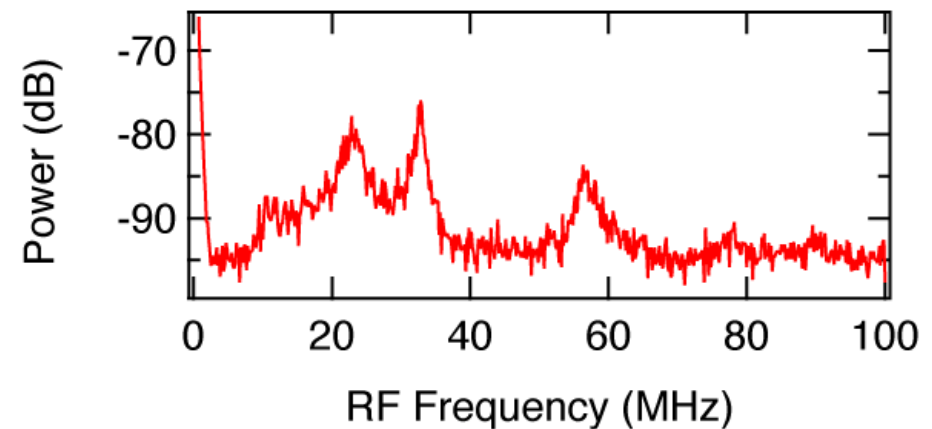
Optical spectrum



Temporal output



RF spectrum



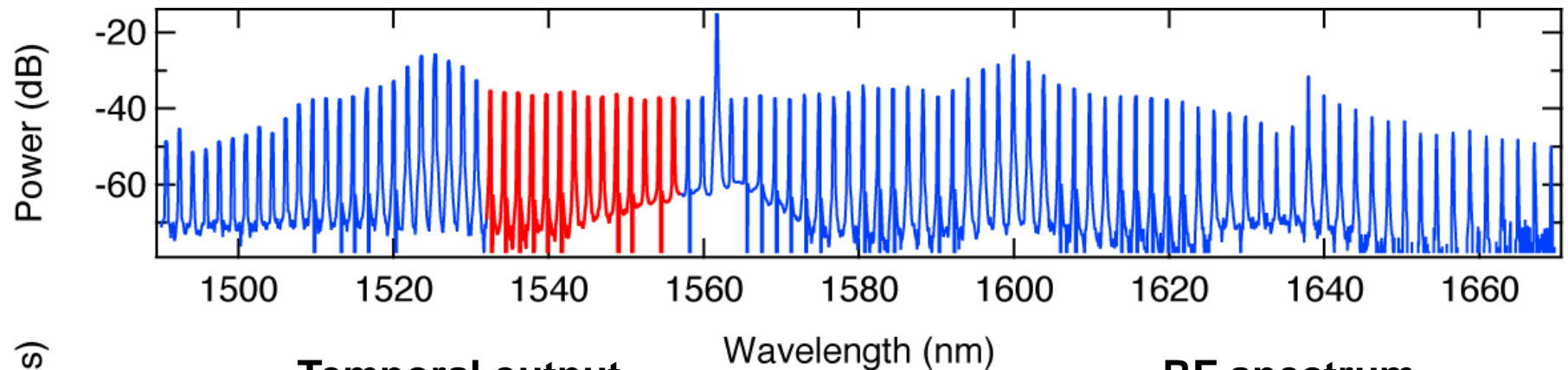


Temporal and Spectral Comb Generation Dynamics

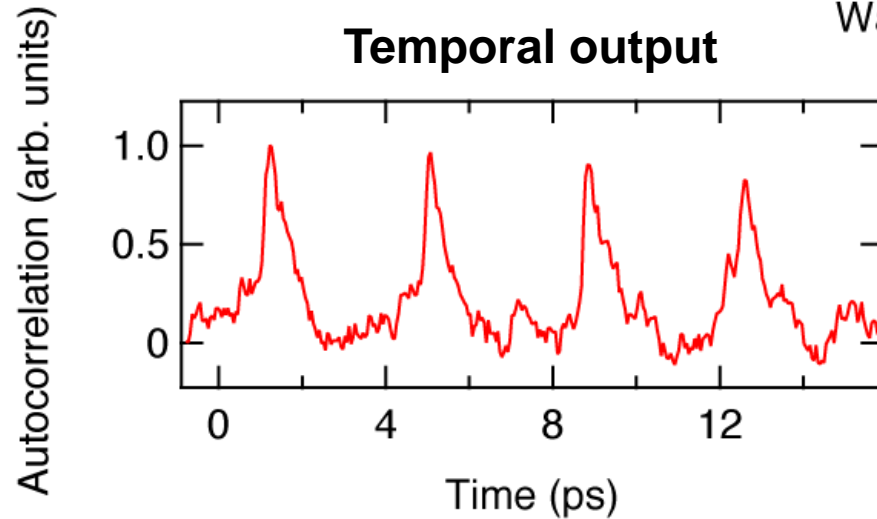


PI: Alex Gaeta, Cornell

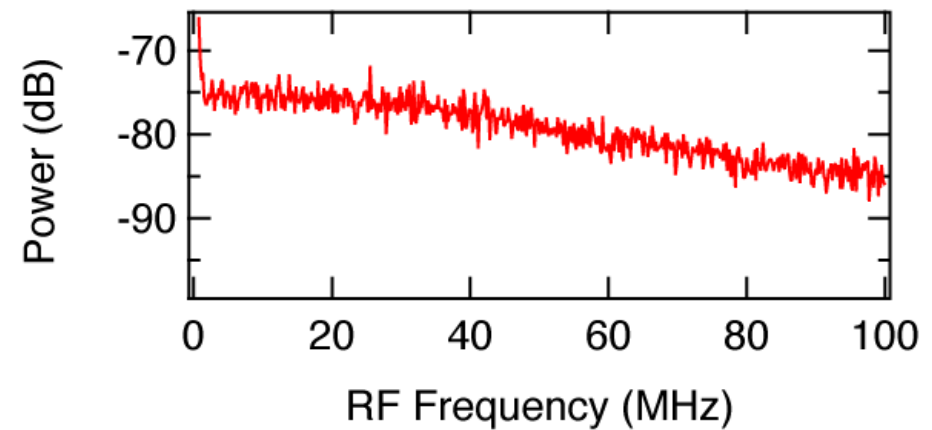
Optical spectrum



Temporal output



RF spectrum



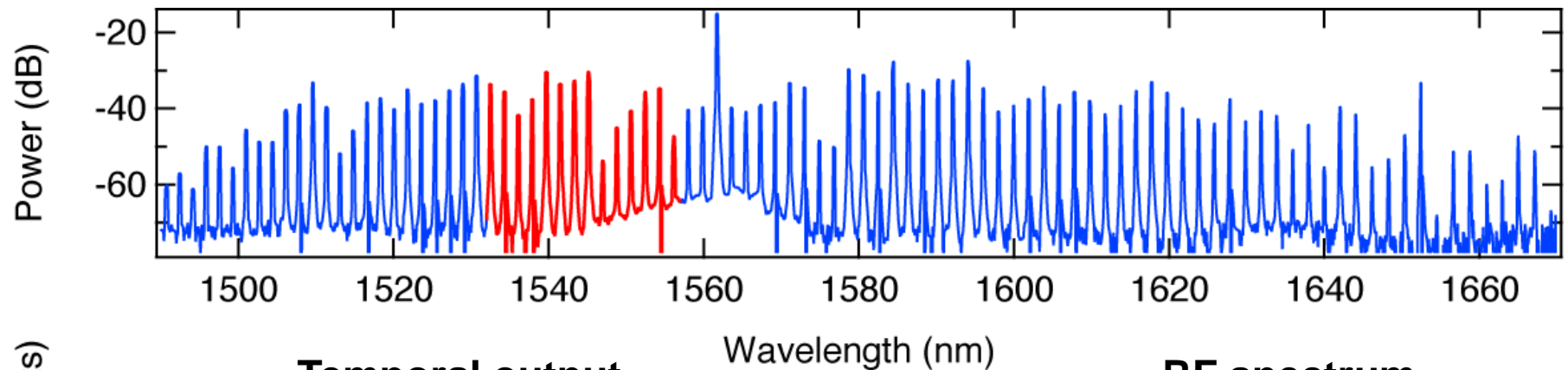


Temporal and Spectral Comb Generation Dynamics

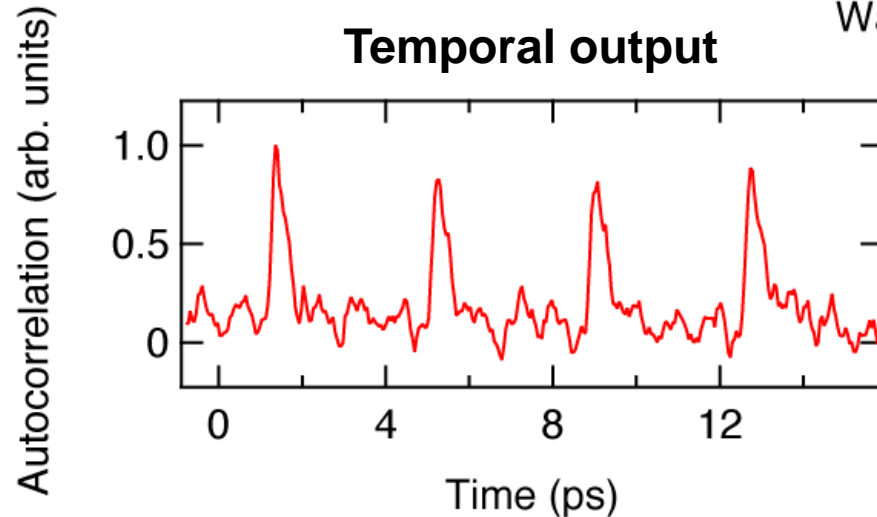


PI: Alex Gaeta, Cornell

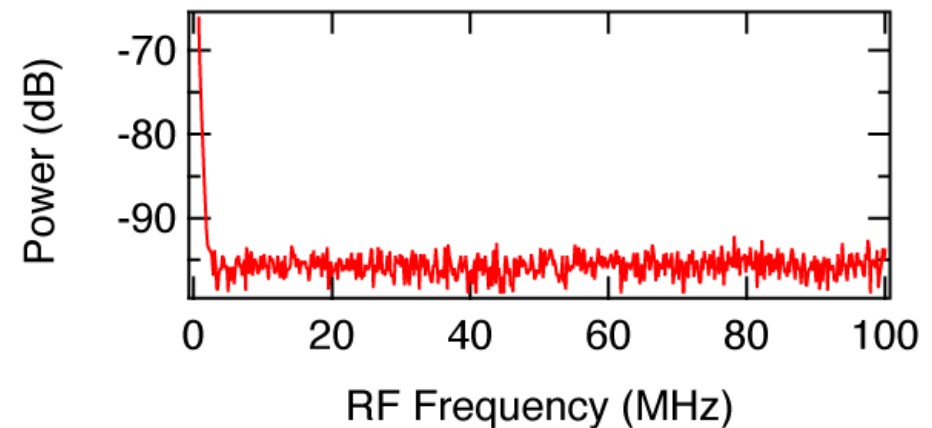
Optical spectrum



Temporal output



RF spectrum



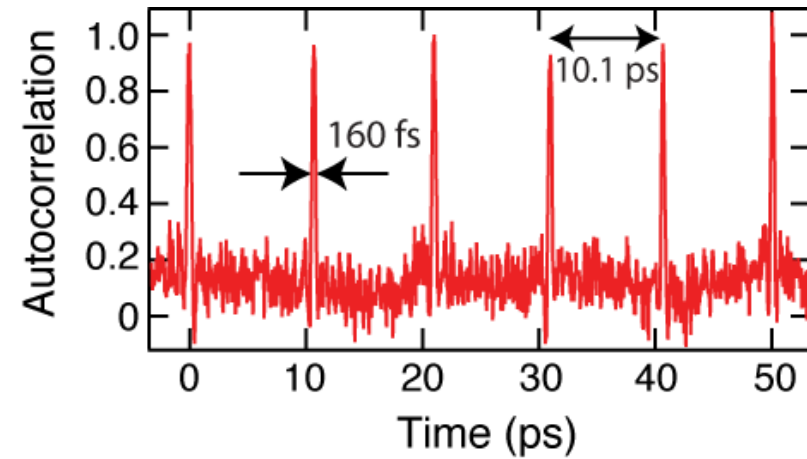
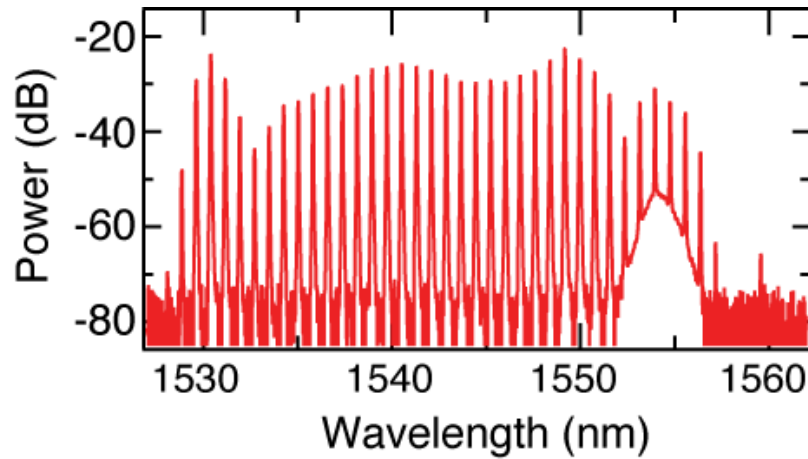
Transition to modelocking?



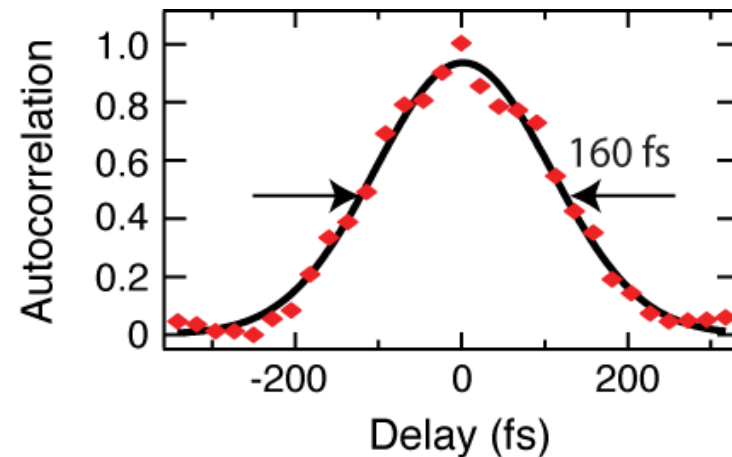
Ultrashort Pulses at 99 GHz



PI: Alex Gaeta, Cornell



- 99-GHz repetition rate
- 160-fs pulses

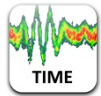




Outline



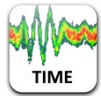
— Microresonator-based optical frequency combs



— **High peak power, ultrashort pulse laser processing of materials**



— Extreme ultraviolet (EUV) comb spectroscopy



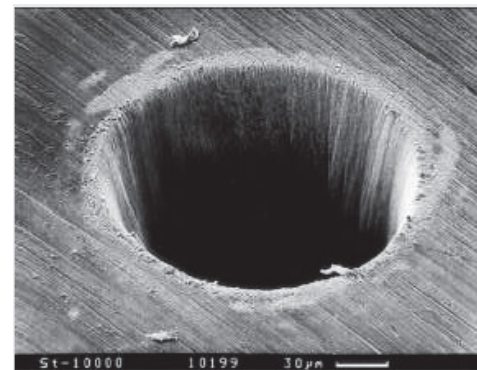
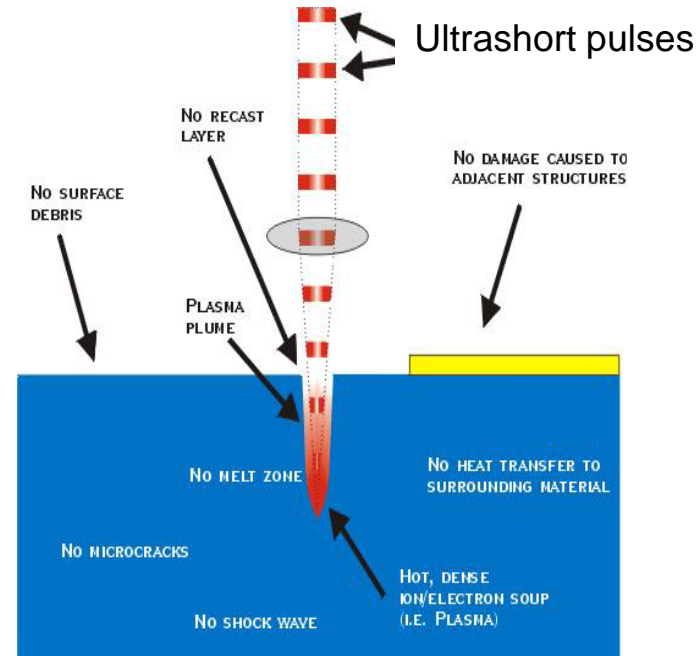
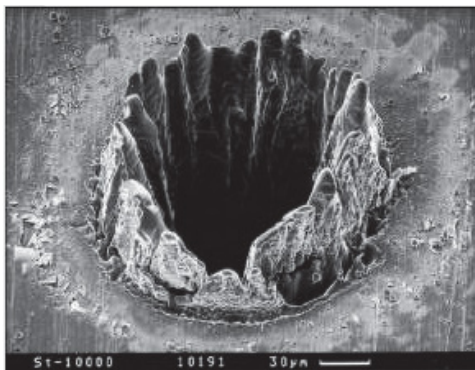
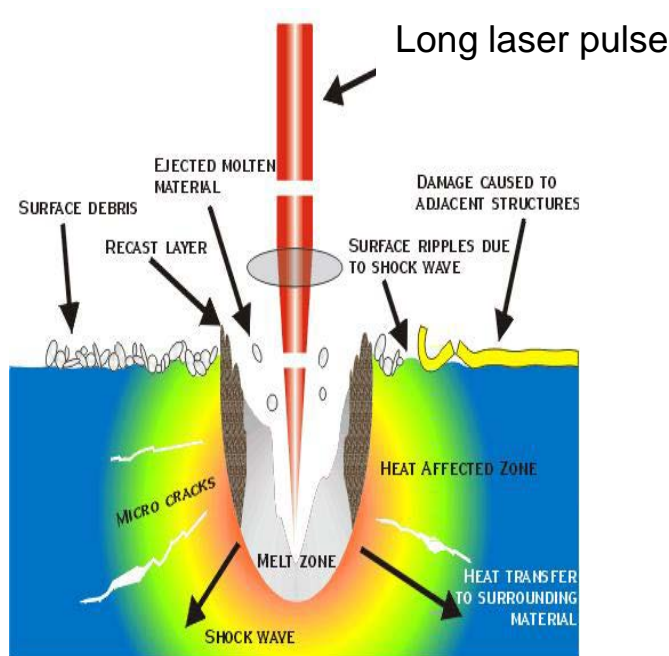
— High harmonic interferometry



— Relativistic optics



Long laser pulse damages adjacent structures Ultrashort pulses → no collateral damage

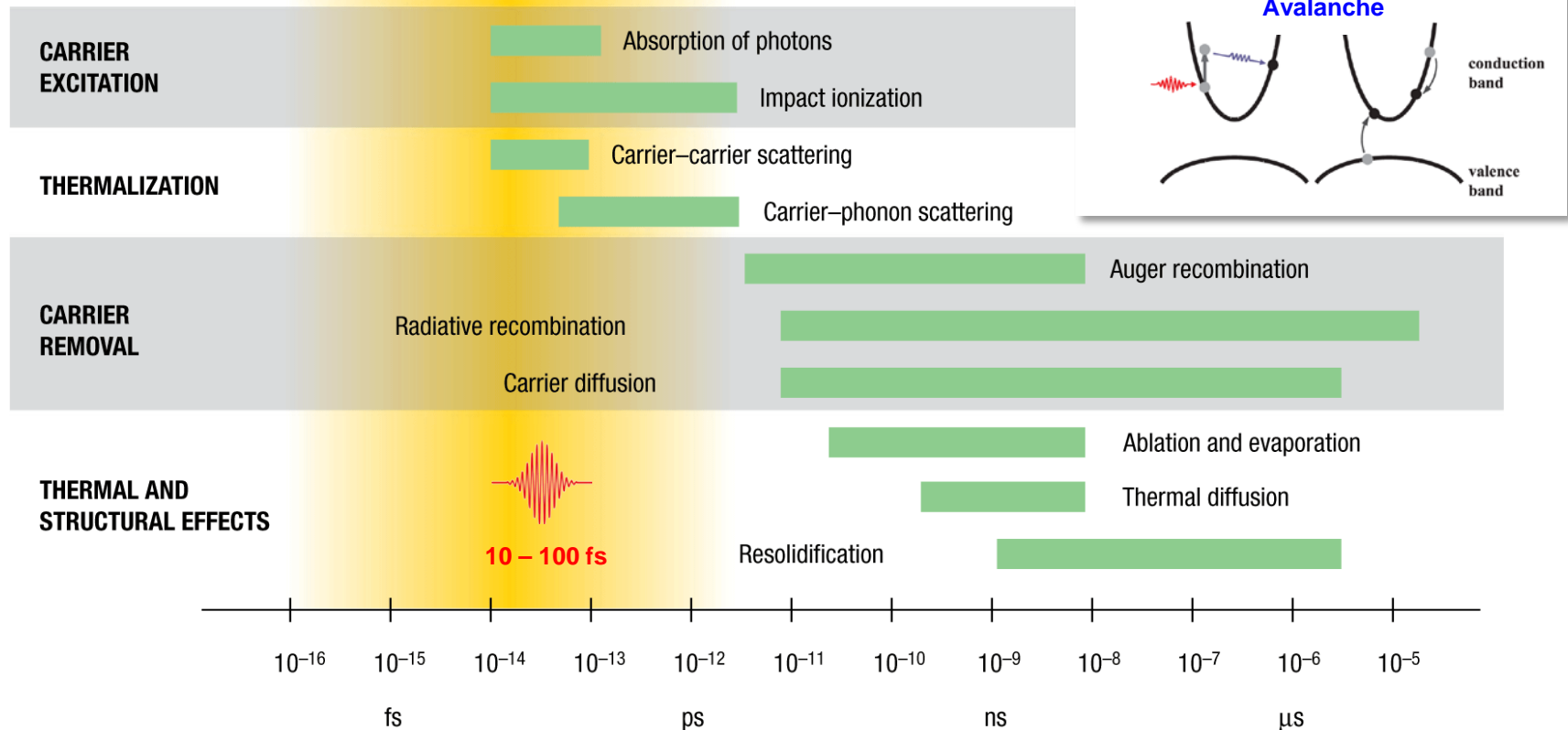




Time-dependent processes in materials



Timescales of electron and lattice processes in laser-excited solids



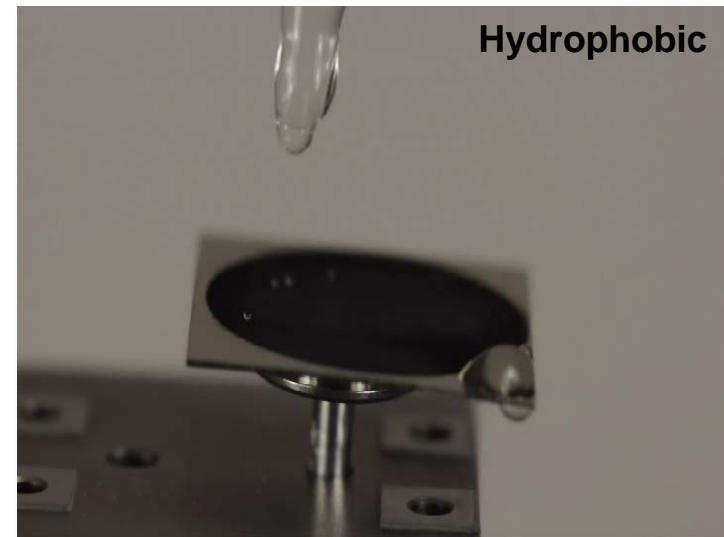
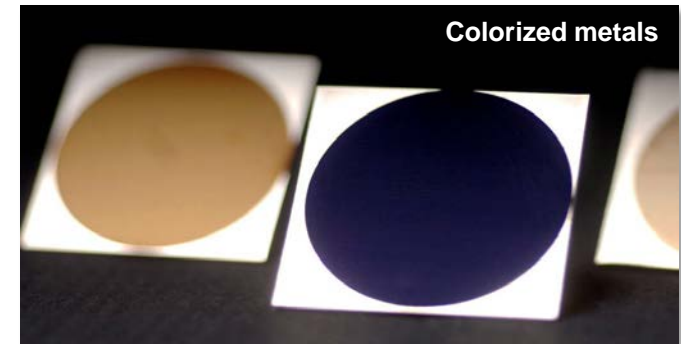


High peak power, ultrashort pulse laser processing of materials



PI: Chunlei Guo, U of Rochester

- Ultrashort laser pulses open up novel possibilities and mechanisms for laser-solid interactions.
- Demonstrated femtosecond laser processing and surface texturing techniques to engineer surface structures & properties (e.g. darkened & colored metals, hydrophilic & hydrophobic surfaces).

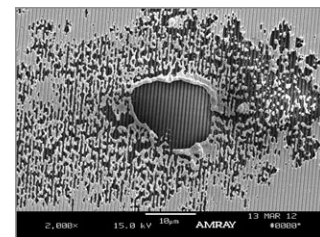
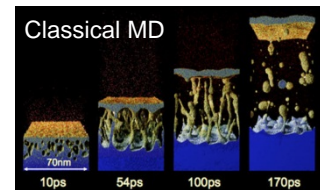




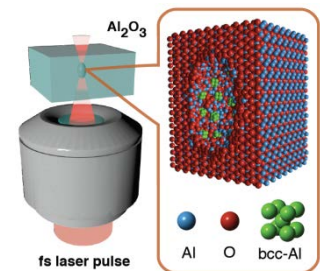
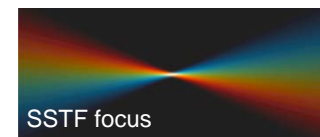
(FY13 BRI) High peak power, ultrashort pulse laser processing of materials



- Initiative aimed at developing a fundamental understanding of intense field laser ablation/damage in the femtosecond regime.
- Three multi-PI efforts exploring:
 - Dynamics of ionization
 - Fundamental dynamics of laser ablation
 - Defect states in multi-pulse interaction
 - Effect of structures on laser damage
 - First principle-based models, non-adiabatic quantum MD, classical MD
 - Vary $\lambda = 400 \text{ nm} - 4 \text{ }\mu\text{m}$, $\tau = 5 - 1000 \text{ fs}$
 - Complex beam shapes (Bessel, Airy, vortex, SSTF beams)
 - Novel laser-matter interaction geometries (confined microexplosions, SSTF excitation, few-cycle pulses)



Gratings





Outline



— Microresonator-based optical frequency combs



— High peak power, ultrashort pulse laser processing of materials



— **Extreme ultraviolet (EUV) comb spectroscopy**



— High harmonic interferometry



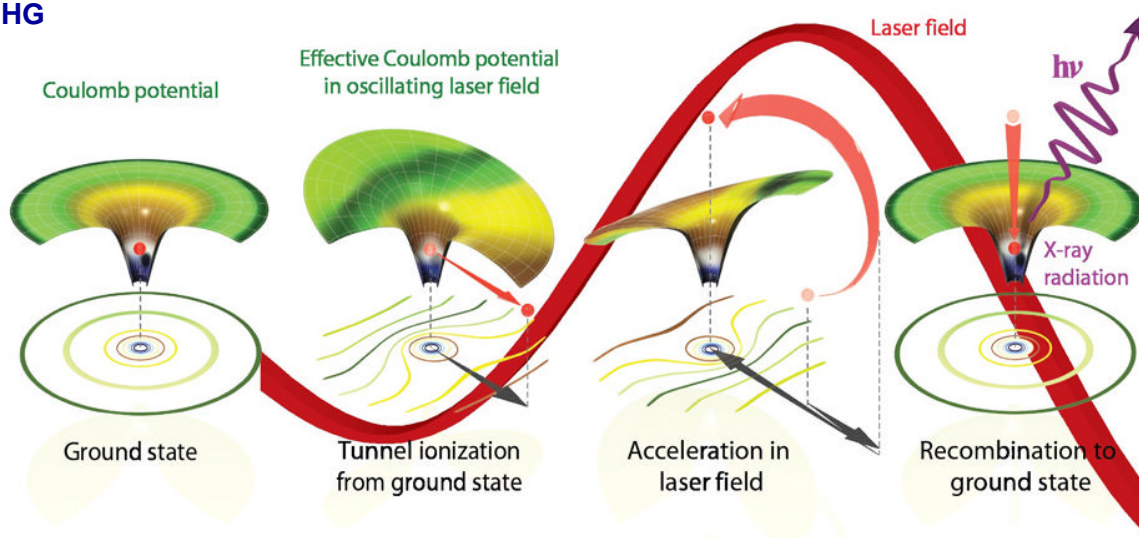
— Relativistic optics



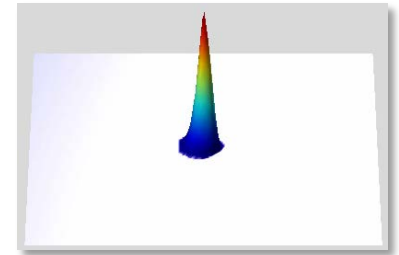
High Harmonic Generation (HHG)



Microscopic single-atom physics of HHG

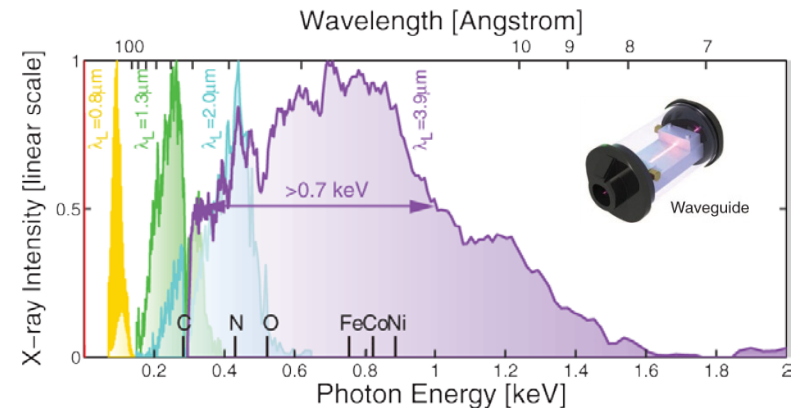
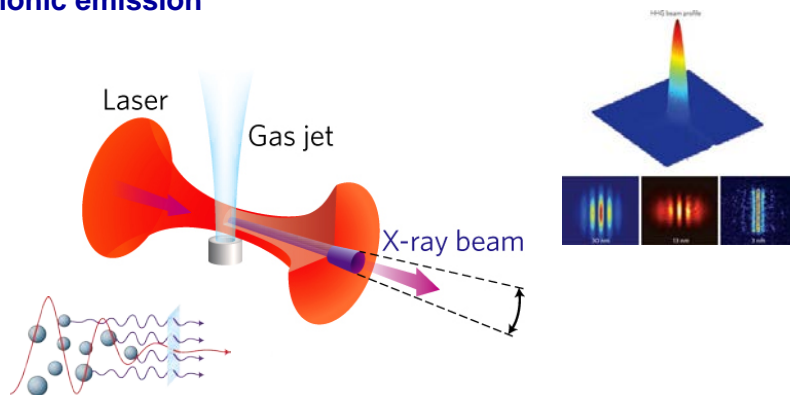


2D electron wavepacket quantum simulation



Source: Luis Plaja, U Salamanca

Macroscopic phase-matched harmonic emission

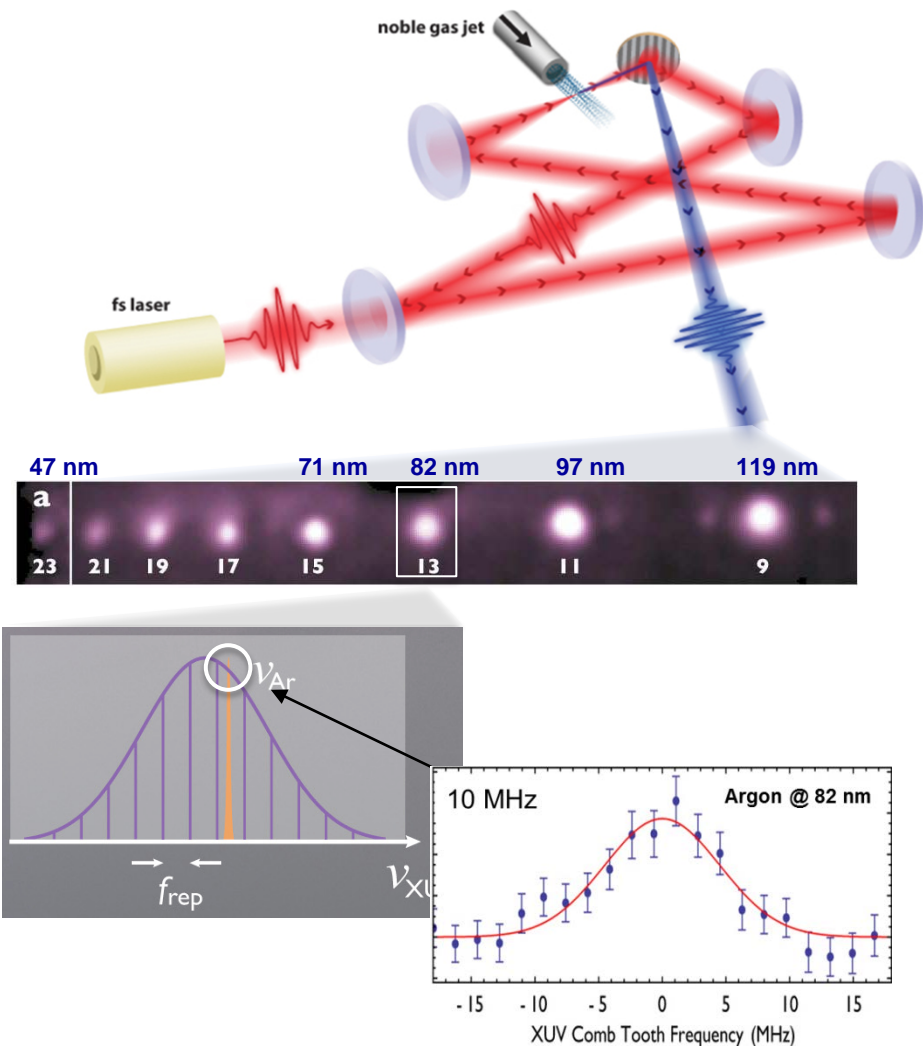




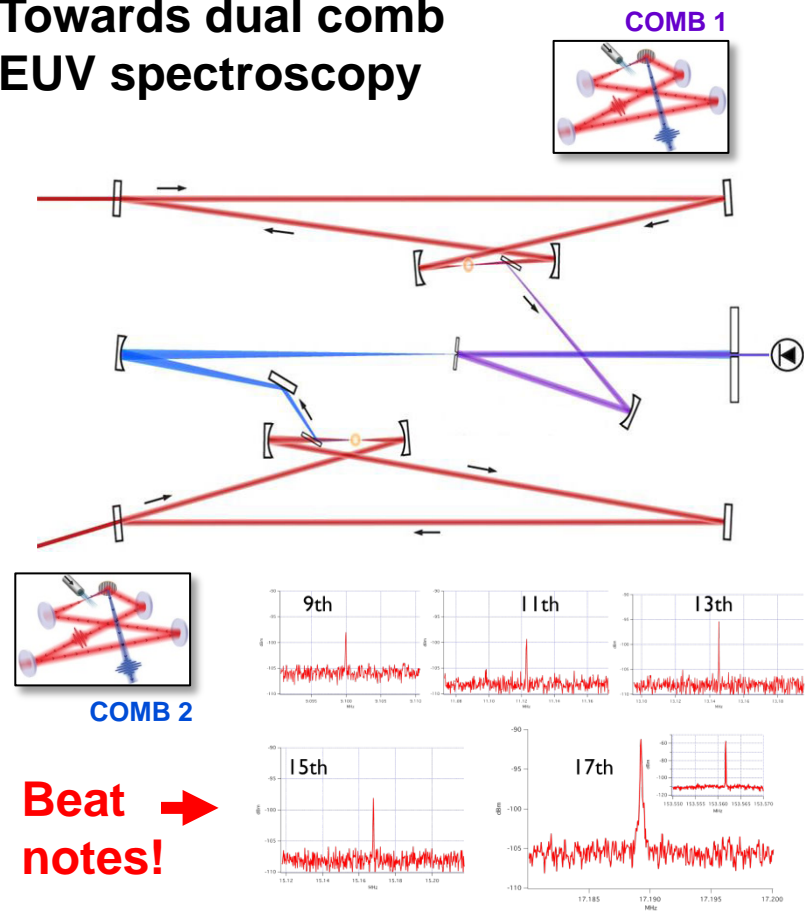
Direct Frequency Comb Spectroscopy in the Extreme Ultraviolet



PI: Jun Ye, U of Colorado



Towards dual comb EUV spectroscopy



Unpublished

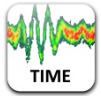




Outline



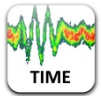
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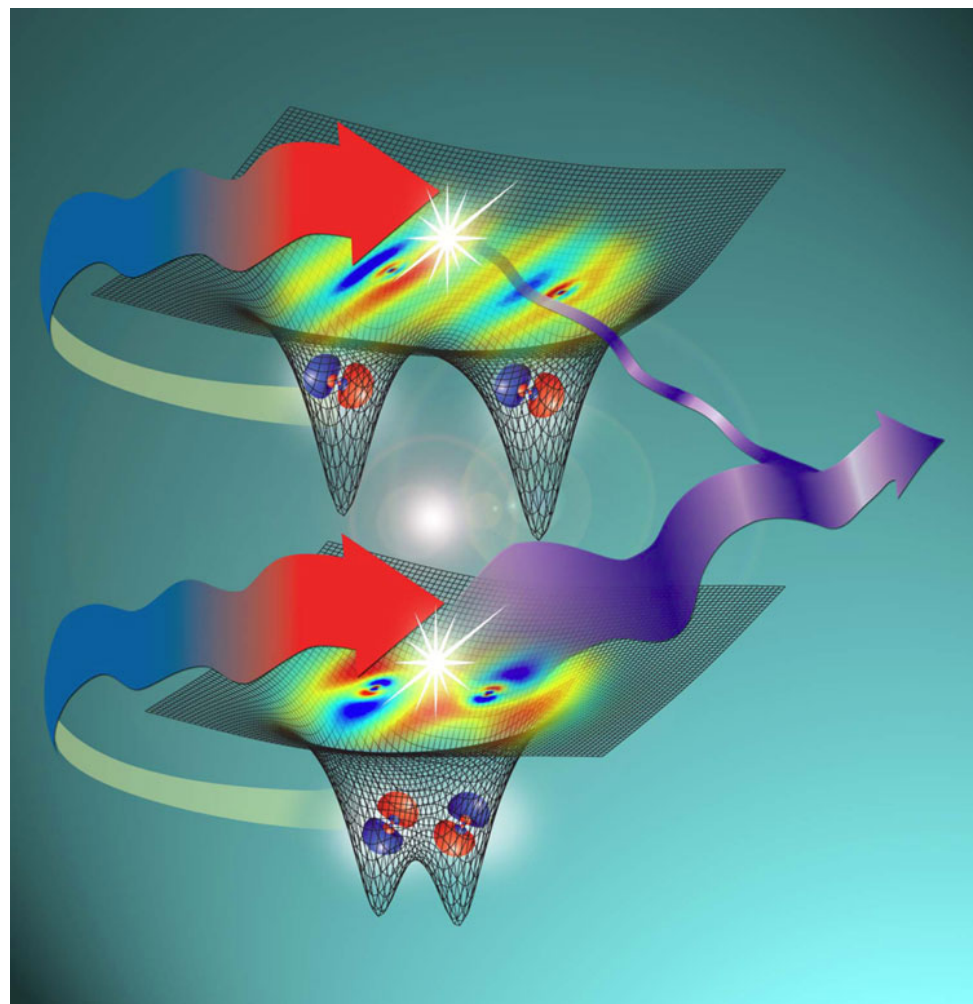
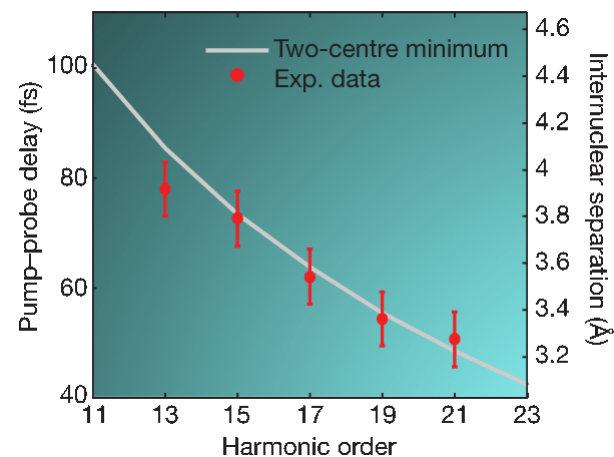
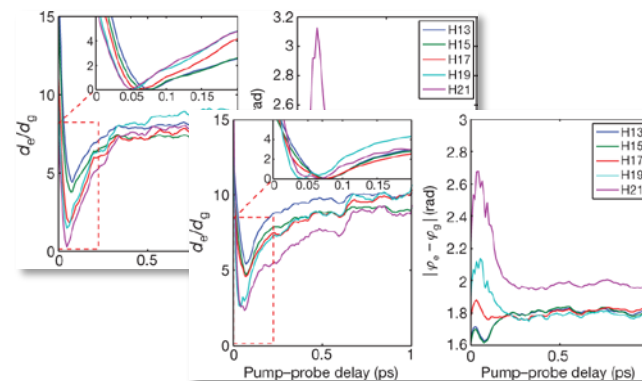
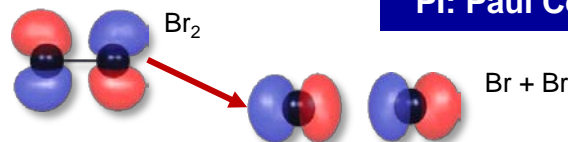
— Relativistic optics



High Harmonic Interferometry to follow chemical reactions



PI: Paul Corkum, NRC

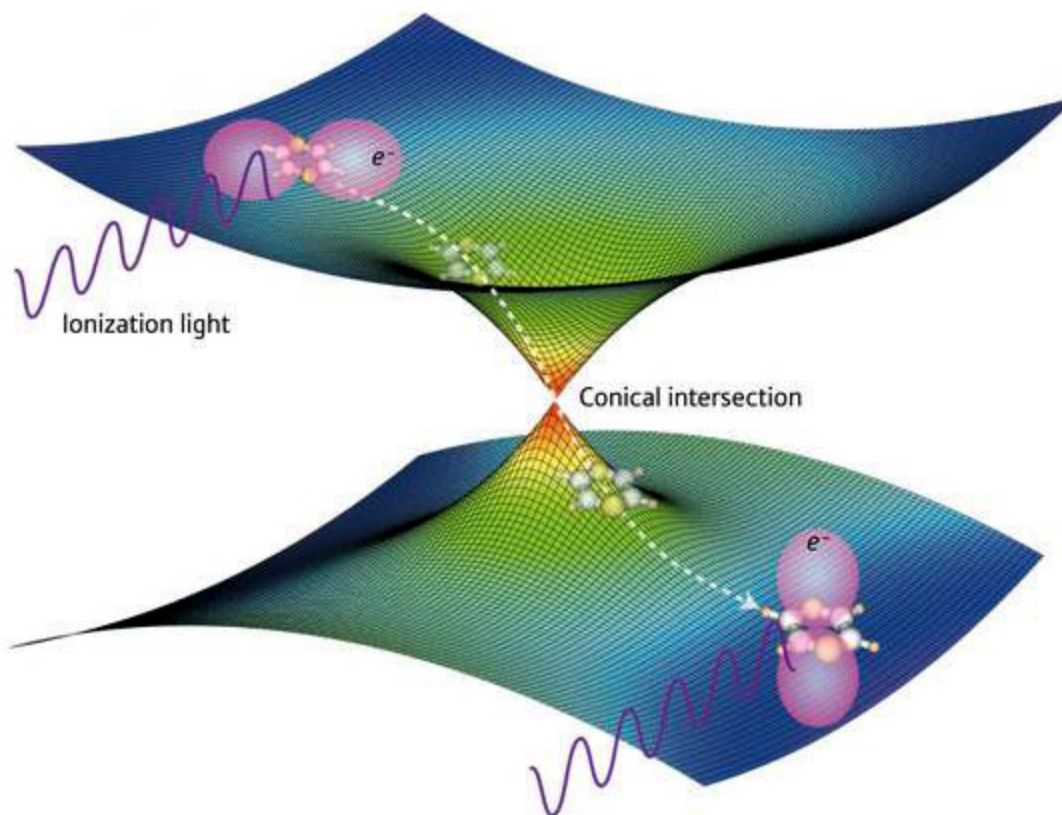




Conical intersections drive the chemistry of complex molecules



PI: Paul Corkum, NRC

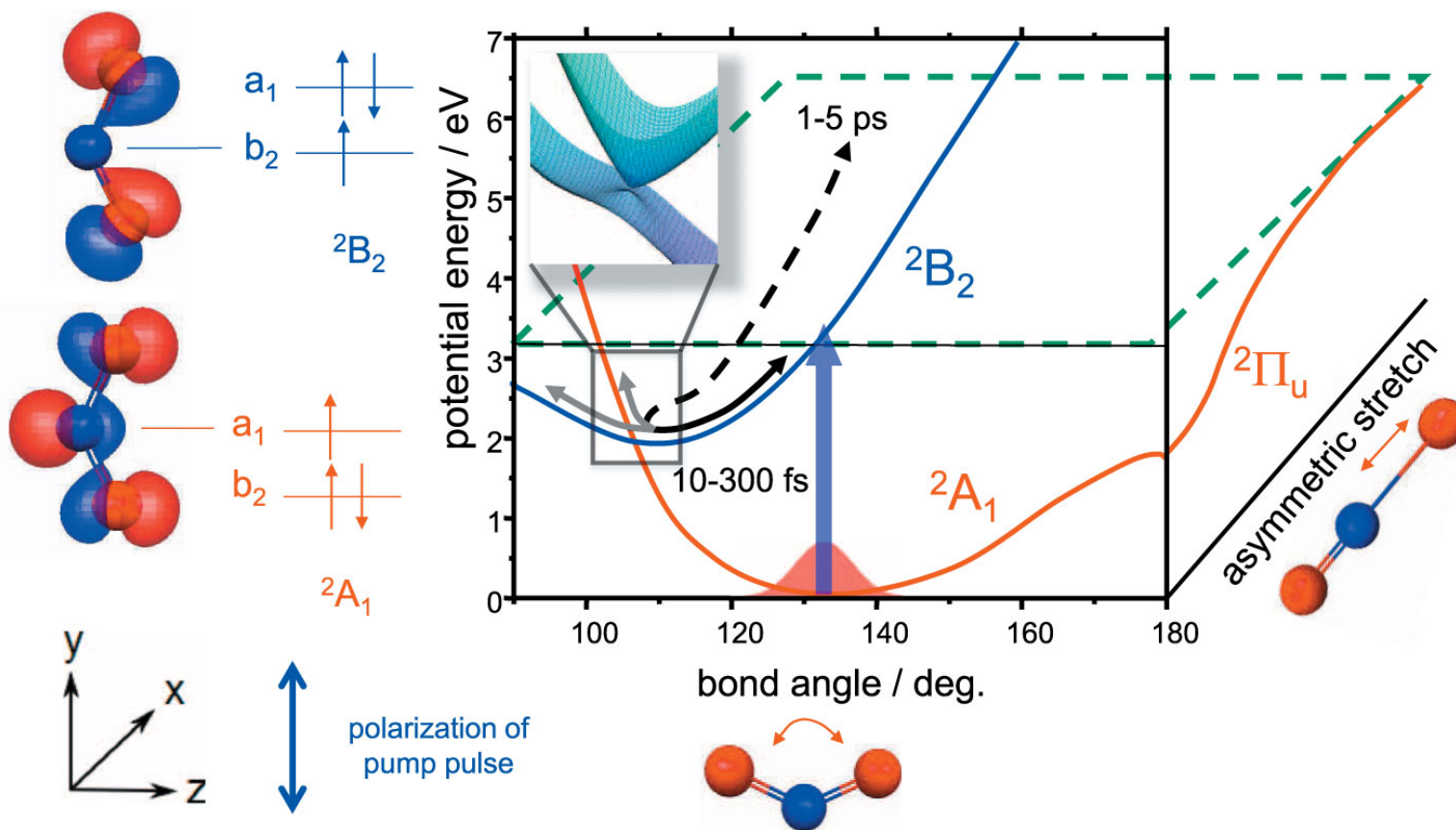




Conical Intersection Dynamics in NO₂



PI: Paul Corkum, NRC

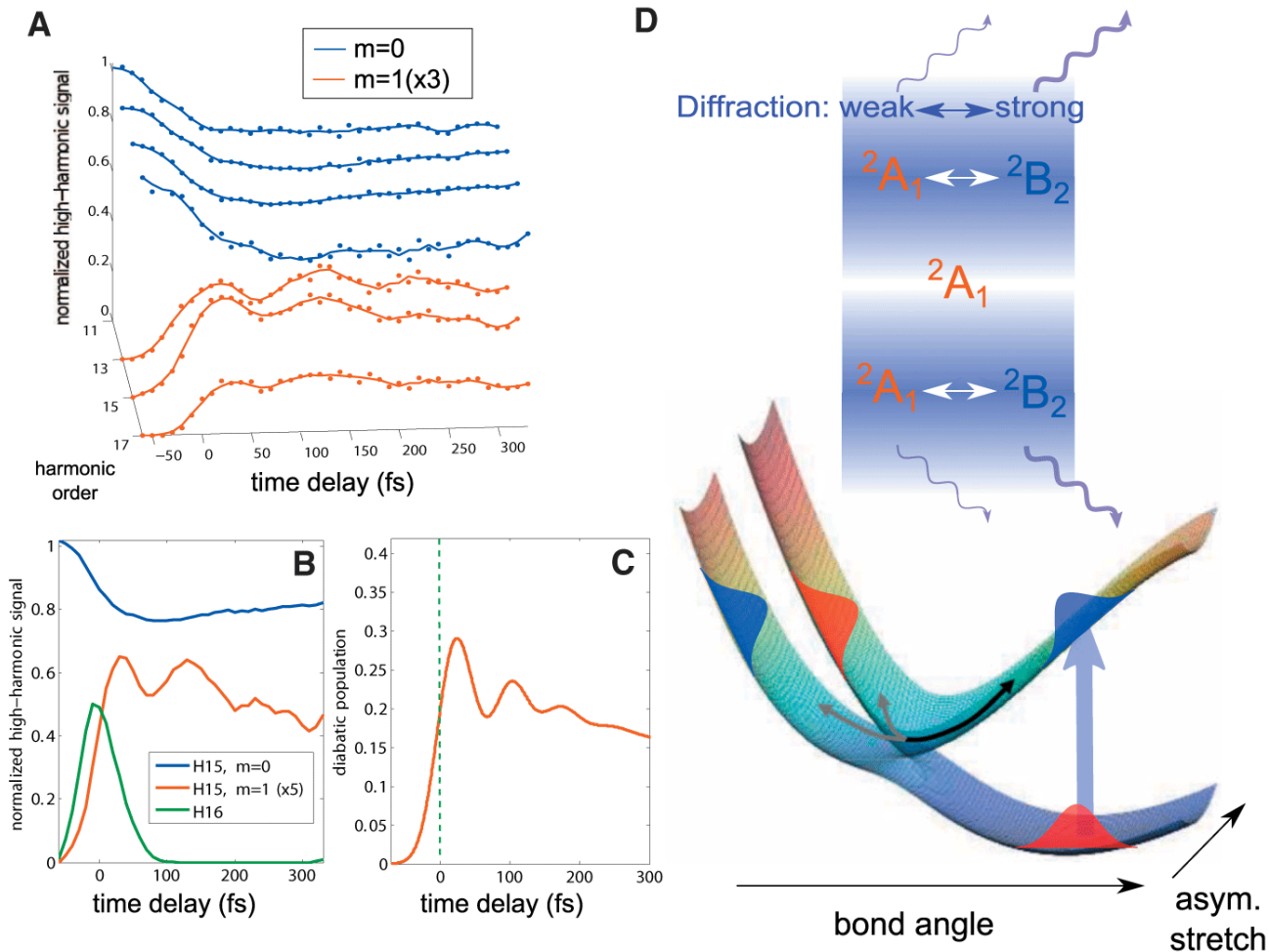




Electronic dynamics near a conical intersection



PI: Paul Corkum, NRC

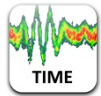




Outline



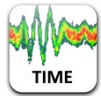
— Microresonator-based optical frequency combs



— High peak power, ultrashort pulse laser processing of materials



— Extreme ultraviolet (EUV) comb spectroscopy



— High harmonic interferometry

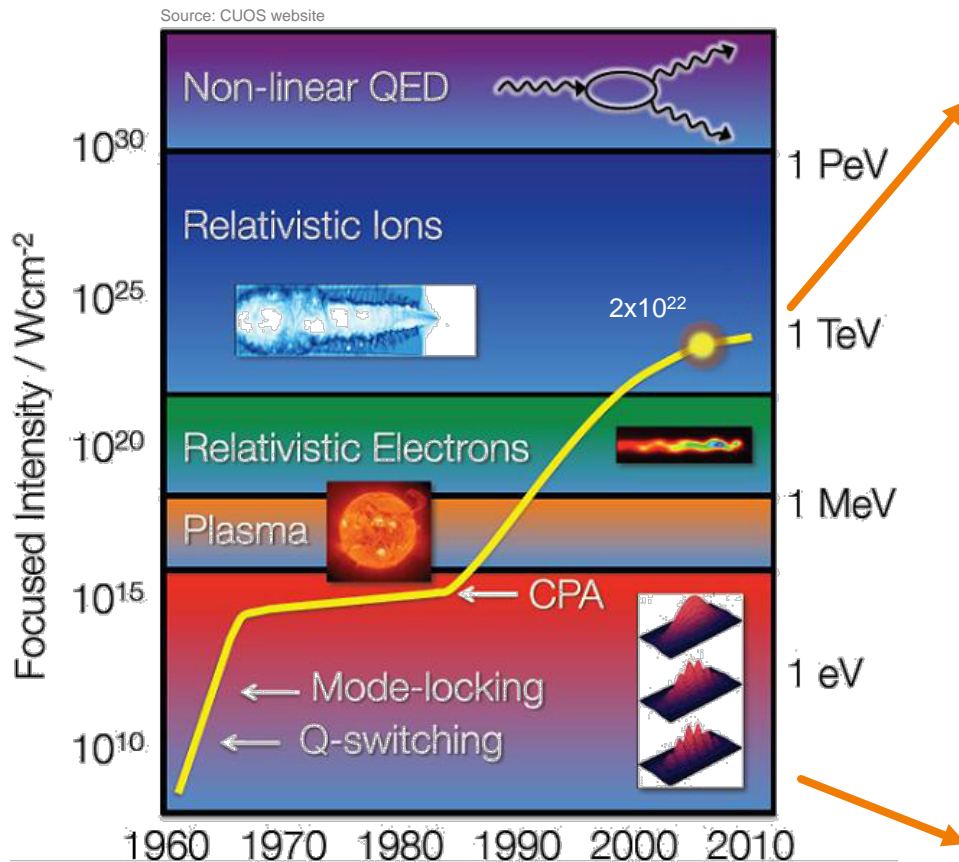


— **Relativistic optics**



Progress in peak intensity

- Over the last two decades, a 6 order of magnitude increase in achieved focused intensities in table-top systems.



Relativistic ions
Nonlinearity of vacuum

GeV e acceleration
e⁺e⁻ production
Nuclear reactions

Relativistic plasmas
Hard x-ray generation

Tunnel ionization
High temperature plasma formation
Bright x-ray generation

Nonperturbative atomic physics
High order nonlinear optics

Perturbative atomic physics
Nonlinear Optics



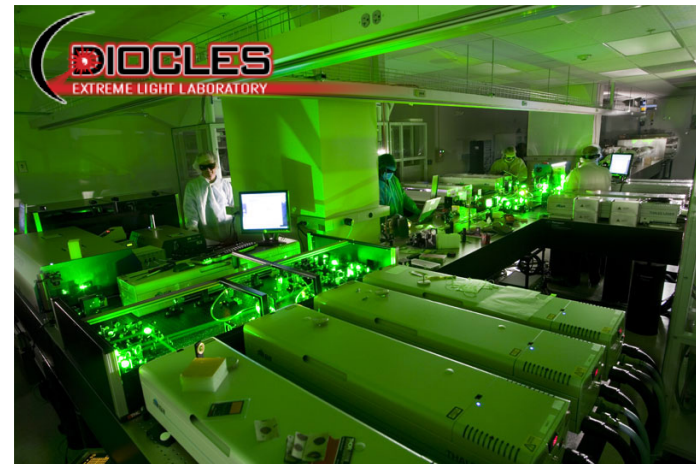
Petawatt class university lasers



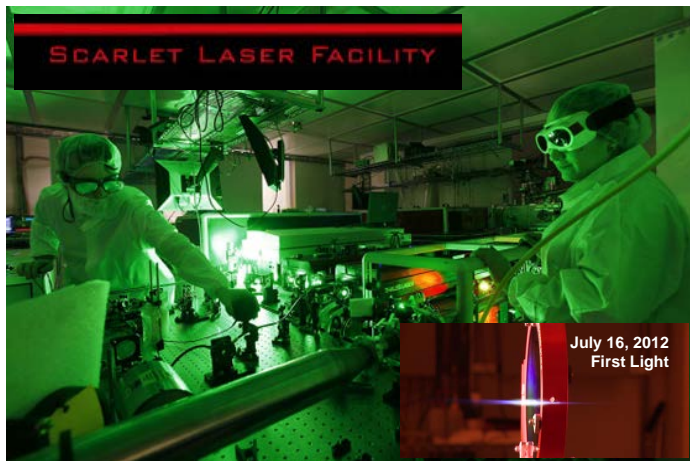
University of Texas, 1.1 PW



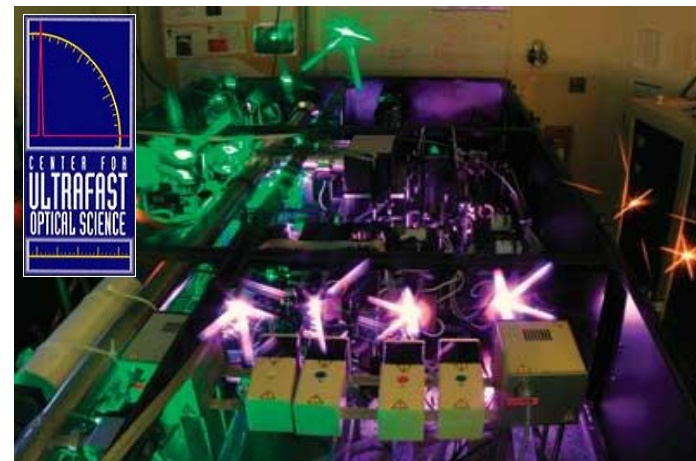
University of Nebraska, 0.7 PW



Ohio State University, 0.5 PW



University of Michigan, 0.3 PW





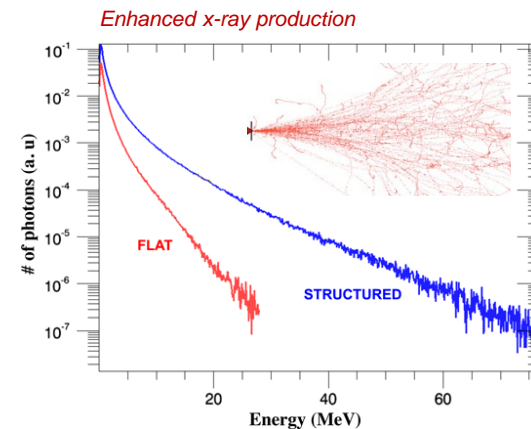
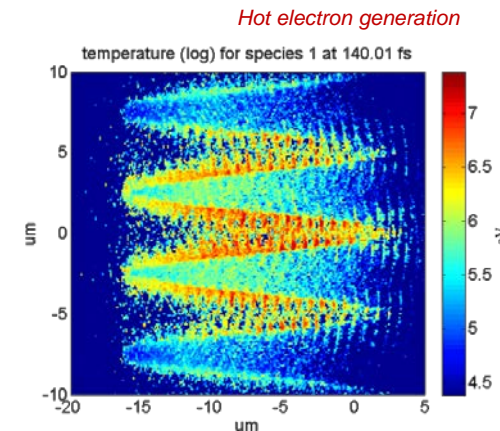
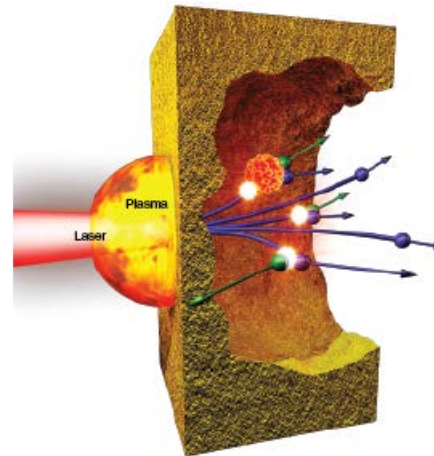
Laser-driven x-ray sources



Picture: Courtesy of Kwei-Yu Chu and
Lawrence Livermore National Laboratory

PI: Kramer Akli, OSU

- Understanding laser-generated electron beam characteristics is the key to advancing x-ray sources.
- PIC simulations of high intensity short pulse laser interacting with structured targets yields an enhancement in the number and energy of hot electron.
- Monte Carlo simulations using the electron beam source from PIC show enhancement of x-ray production.



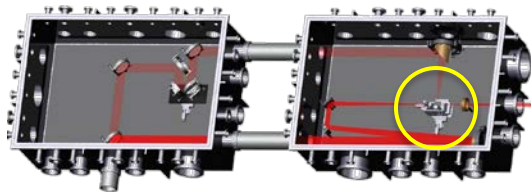


Laser-driven x-rays generation (0.1 – 10 MeV)

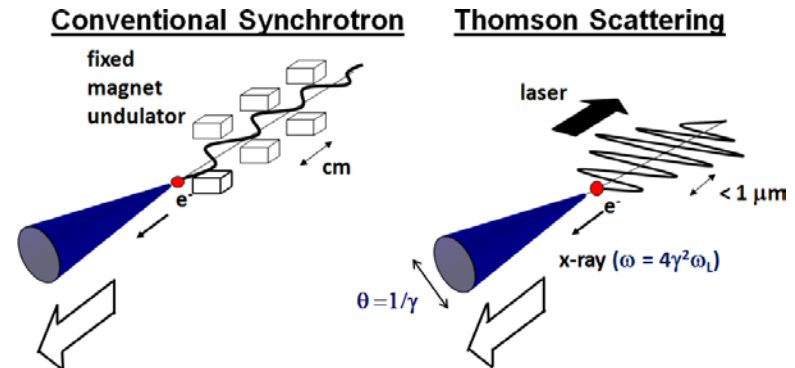
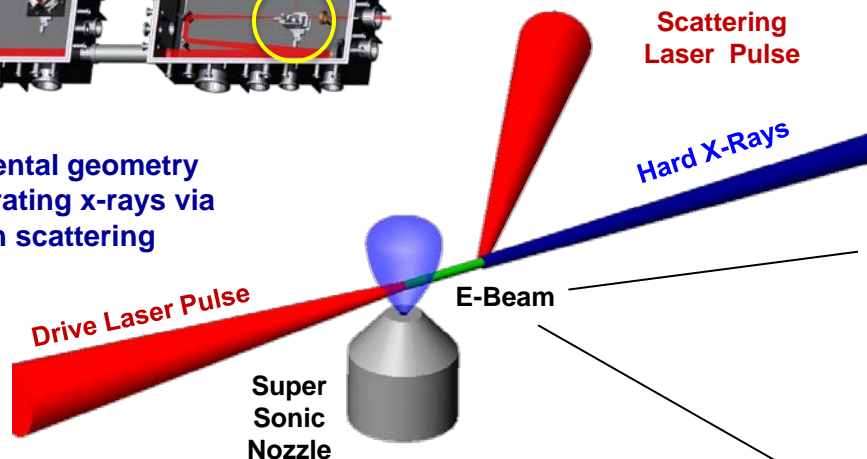


PI: Donald Umstadter, U of Nebraska

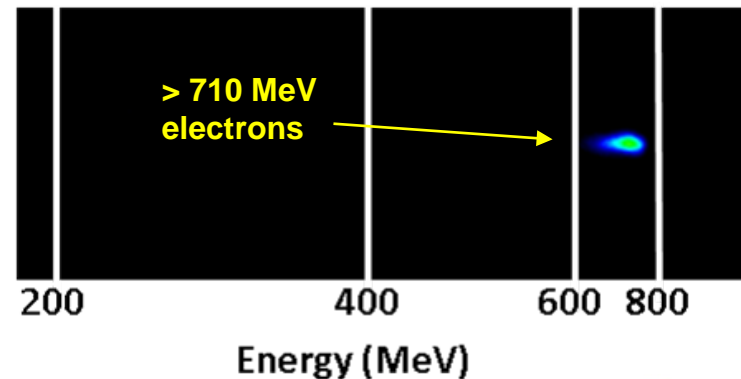
- Scattering from a 300 MeV electron beam can Doppler shift a 1-eV energy laser photon to 1.5 MeV energy.
- Demonstrated > 710 MeV electron beams with no detectable low-energy background.



Experimental geometry for generating x-rays via Thomson scattering



Energy tunability from 0.1 – 0.8 GeV.
Monoenergetic: $\Delta E/E \sim 10\%$
Low angular divergence: 1-5 mrad

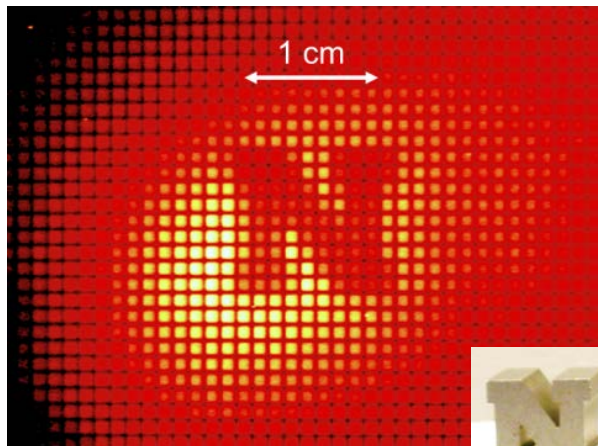
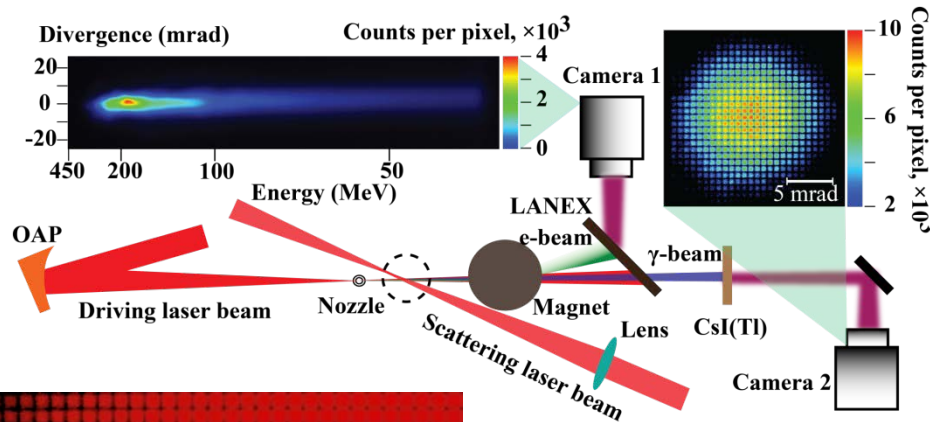




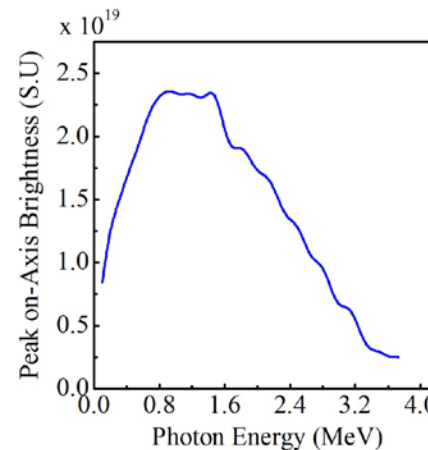
Laser-driven x-rays generation (0.1 – 10 MeV)



PI: Donald Umstadter, U of Nebraska



0.5 inch thick steel plate



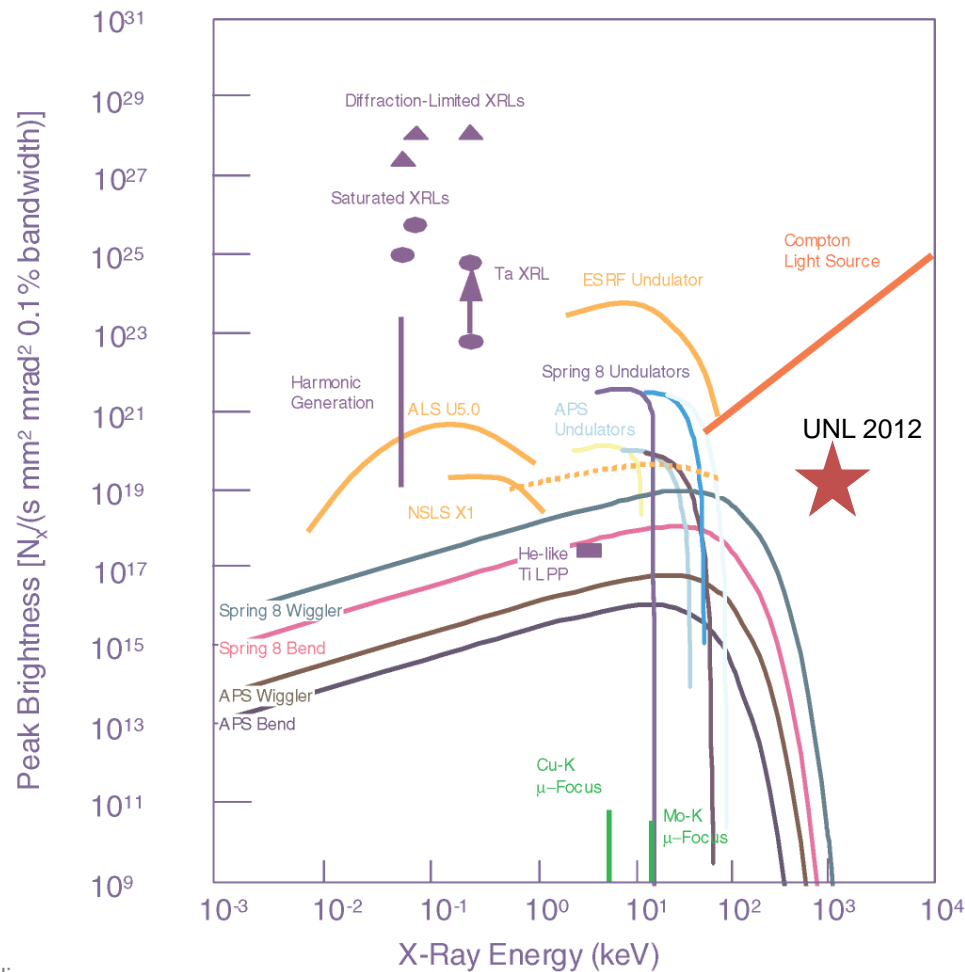
Beam	Parameter	Sym	Value
ω_0	Energy	E_{laser}	0.5 J/ pulse
	Wavelength	λ	800 nm
	Pulse duration	τ_s	90 fs (FWHM)
	Spotsize	σ_L	$9.4 \pm 0.4 \mu\text{m}$ (RMS)
	Number of laser oscillations/pulse	N_{laser}	34
	Average power	P_L	5.6 TW
	Normalized field strength	a_0	0.4
	Photon energy	E_L	1.5 eV
	Interaction angle	Φ	170 deg
e	Source size	σ_e	$6.0 \pm 2.6 \mu\text{m}$ (RMS)
	Cutoff energy ⁱ	E_c	250 MeV
	Divergence ⁱⁱ	θ_e	5 mrad (FWHM)
	Total charge	Q	120 pC
γ	Source size	σ_γ	$5.1 \pm 2.6 \mu\text{m}$ (RMS)
	Divergence	θ_γ	12.7 mrad (FWHM)
	Peak energy	E_γ	1.2 MeV
	Total photon number/pulse	N_γ	$\sim 10^7$
	Peak on-axis brilliance	B_s	2.3×10^{19} photons/s-mm ² -mrad ² (0.1% BW)



Brighter, more energetic and tunable than conventional synchrotrons



PI: Donald Umstadter, U of Nebraska



Hartemann, F. V. et al. High-energy scaling of Compton scattering light sources. Physical Review Special Topics - Accelerators and Beams 8, 100702 (2005).

DISTRIBUTION A: Approved for public release; distribution is unlimited

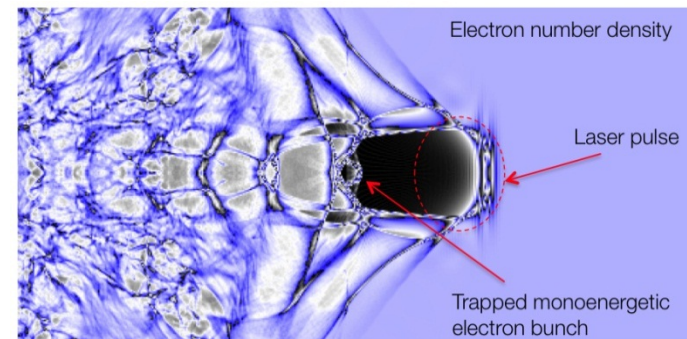




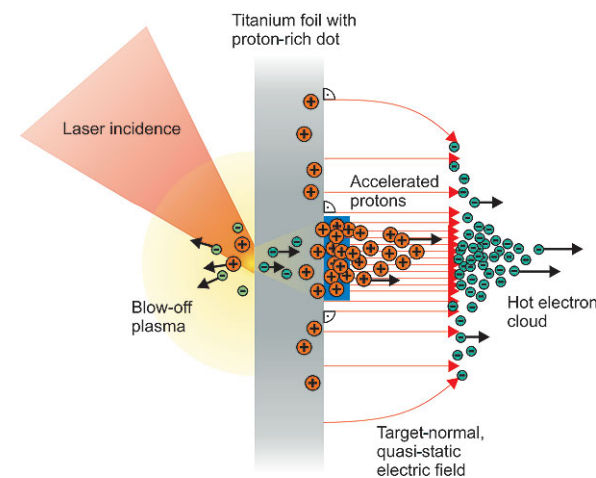
(FY14 BRI) Laser-matter interactions in the relativistic optics regime



- **Laser-driven electron acceleration**
 - **Laser Wakefield Acceleration:** Electrons are accelerated to giga-electronvolt (GeV) energies over centimeters distances
 - **Direct Light Acceleration**
- **Ion acceleration**
 - Protons and ions are accelerated to mega-electronvolt (MeV) energies by a mechanism known as ‘target normal sheath acceleration’ (TNSA)
- **X-ray radiation sources**
 - keV to MeV x-rays via non-linear Thomson Scattering
 - K α monochromatic emission
 - Bremsstrahlung broadband radiation
- **Neutron sources**
 - Protons incident on a secondary target (e.g. Lithium) can produce MeV neutrons
- **QED physics**



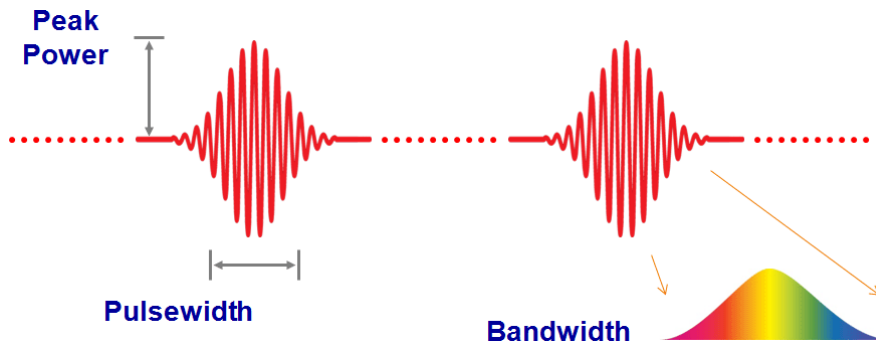
Electron density distribution and generation of quasi-monoenergetic electron bunches observed in PIC simulations.



Target Sheath Normal Acceleration: Laser acceleration of protons from the back side of a microstructured target.



Summary and outlook



The program aims to understand and control light sources exhibiting extreme temporal, bandwidth and peak power characteristics.

Optical frequency combs

ultra-wide bandwidths

- Spectral coverage to exceed an octave with high power/comb.
- Coherence across EUV-LWIR.
- Novel resonator designs (e.g. micro-resonator based).
- Ultra-broadband pulse shaping.
- ...

High-field laser physics

high peak powers

- Laser-solid interactions.
- Fs propagation in media.
- Sources of secondary photons.
- Compact particle accelerators.
- High peak power laser architectures.
- High repetition rates.
- New wavelengths of operation.
- ...

Attosecond science

ultrashort pulsewidths

- Efficient, high-flux generation.
- Pump-probe methods.
- Probe atoms/molecules & condensed matter systems.
- Attosecond pulse propagation.
- Novel attosecond experiments.
- Fundamental interpretations of attosecond measurements.
- ...